

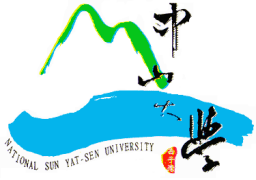
The Art and Science of Packaging High-Coupling Photonics Devices and Modules

藝術與科學結合之高耦光元件與模組構裝

Wood-Hi Cheng

**Department of Photonics, National
Sun Yat-sen University, Kaohsiung,
Taiwan**

**December 13 16,
2011**



Outline

1. Motivation and Review

2. First Generation Microlens

One-Mechanical Torque Control

3. Second Generation Microlens

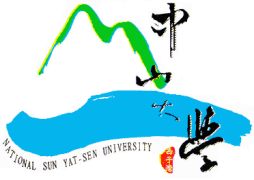
Two-Electrical Torques Control

4. Third Generation Microlens

Three-Electrical Torques Control

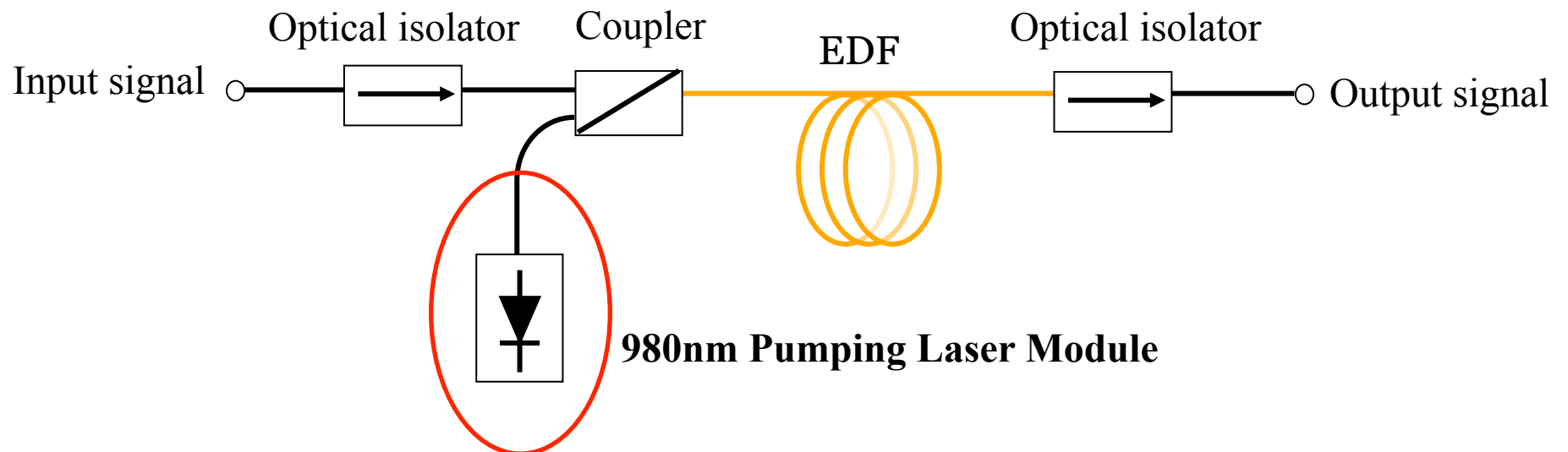
5. Near-Field Measurements

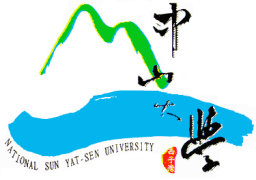
6. Conclusion



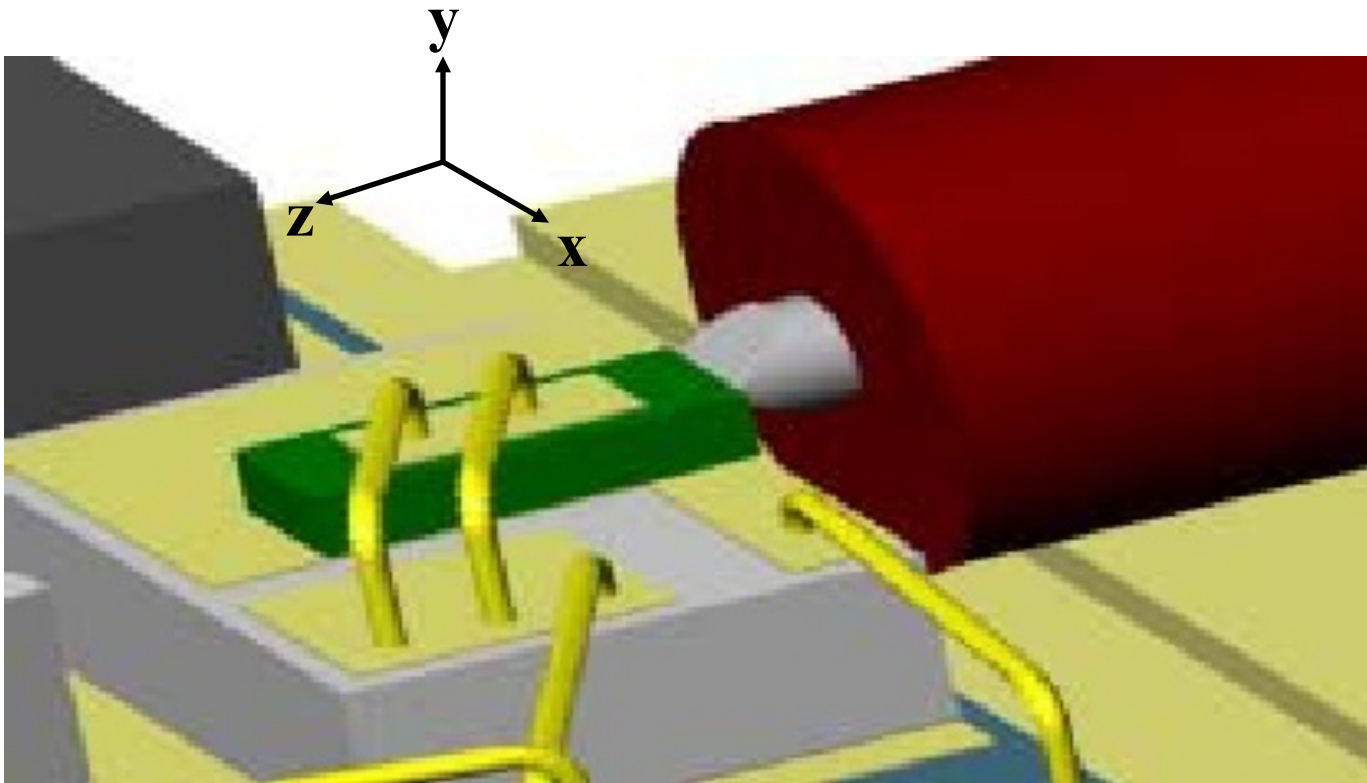
EDFA Components

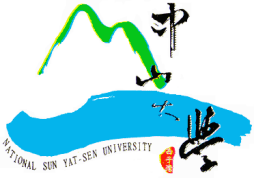
- Erbium-Doped Fiber Amplifier (EDFA)





Coupling Setup

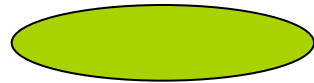




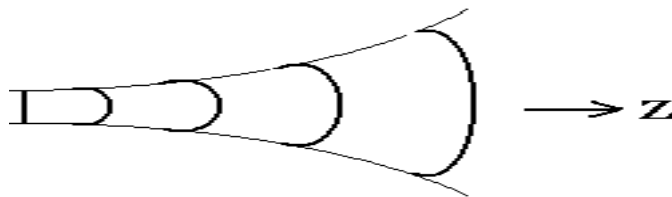
Mode Mismatch

● 980nm Laser

Elliptic Mode Field

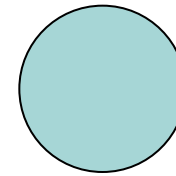


Curved Wavefront

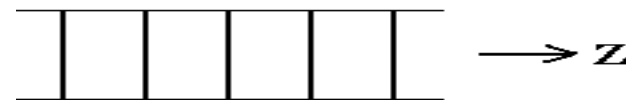


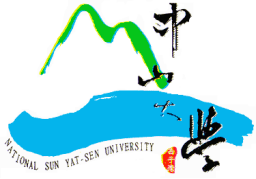
● Standard SMF

Circle Mode Field



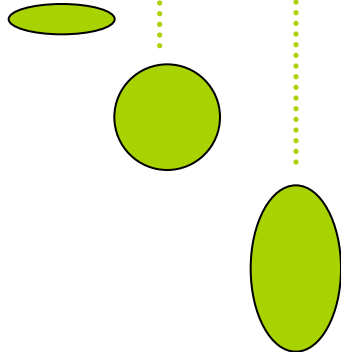
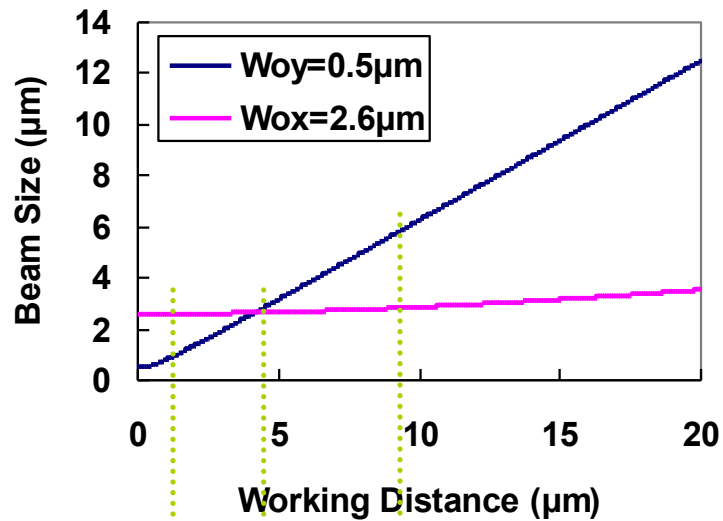
Planar Wavefront



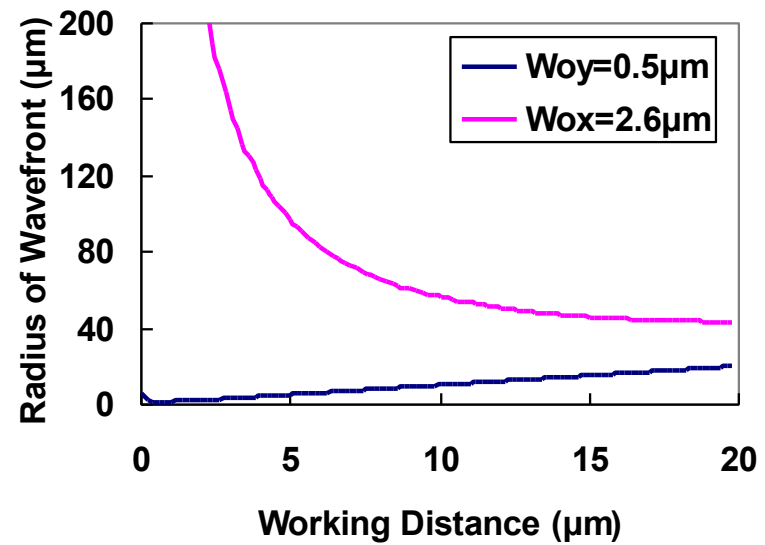


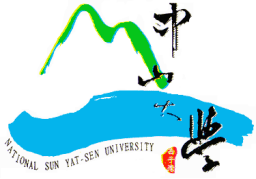
Spot Size and Wavefront in 980-nm Laser

Spot size

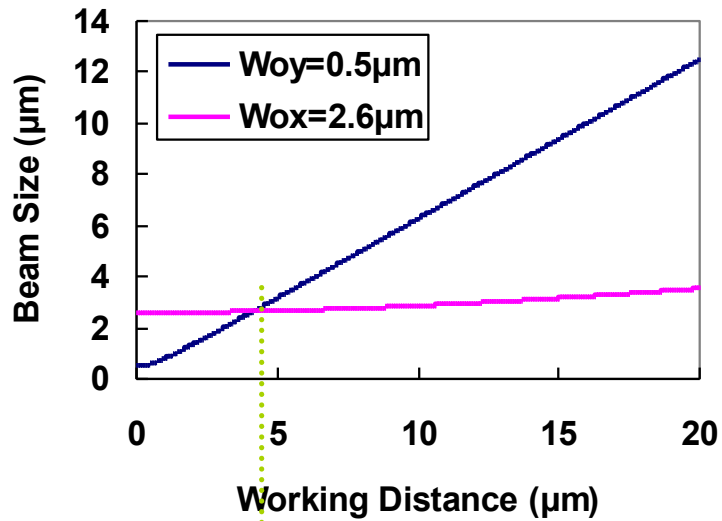



Wavefront



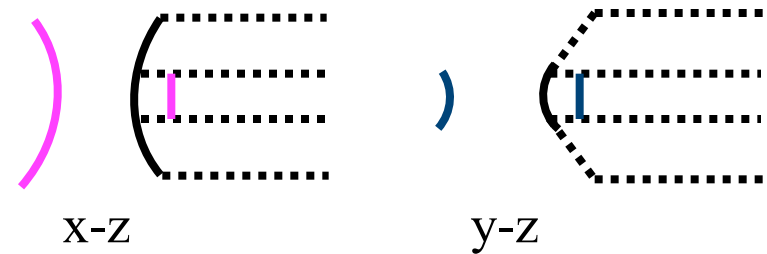
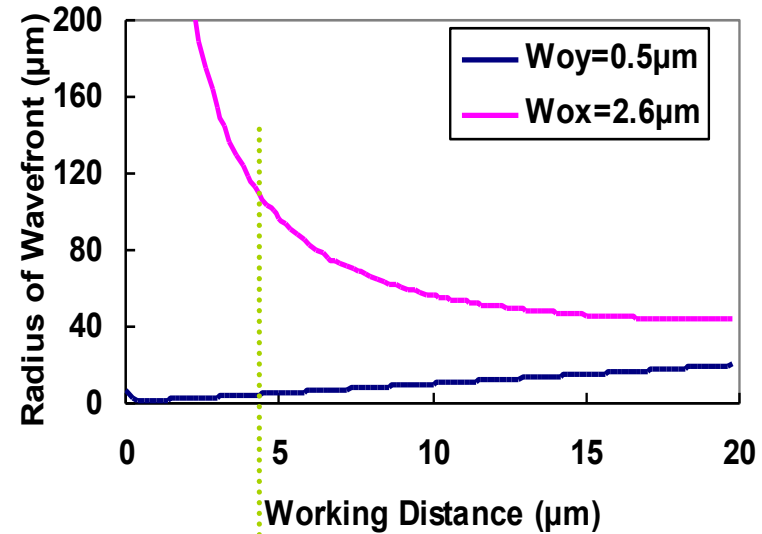


Mode Matching of Microlens Design

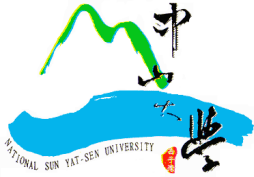



 $\omega_x(z) = \omega_y(z) \sim \omega_f$

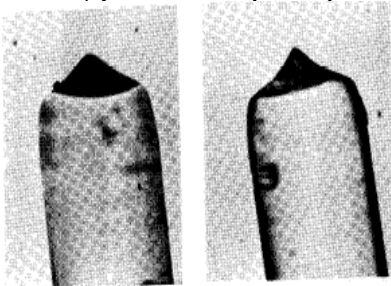
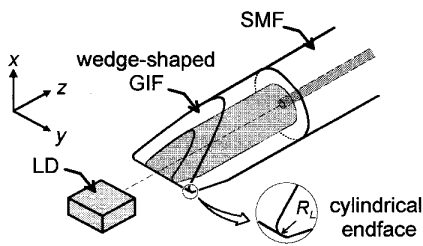
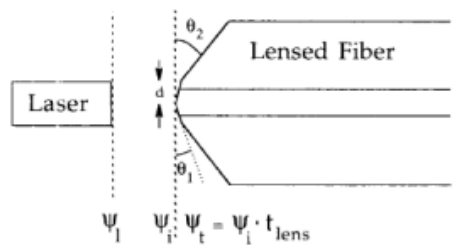
(a) Spot size matching



(b) Wavefront matching



Article Reviews

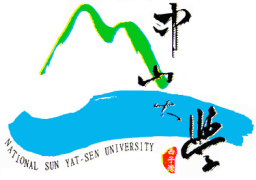
Lens shape	Hyperbolic [1-2] 	Wedge-shaped GIF [3] 	Double Wedge-shaped [4] 
Critical technique	CO ₂ Laser processing	Fiber fusion & Fiber polish	Fiber polish
Coupling efficiency	78%	30%	78%
Advantages	High coupling efficiency	High power MM laser	High coupling efficiency
Disadvantages	Expensive equipment Low yield	Complicated process Low reproducibility	Low reproducibility Low yield

[1]H. M. Presby and C. A. Edwards, "Efficient Coupling of Polarization-Maintaining Fiber to Laser Diodes," IEEE Photonics Technology Letters, Vol. 4, pp. 897-899, 1992.

[2]H. M. Presby and C. R. Giles, "Asymmetric Fiber Microlenses for Efficient Coupling to Elliptical Laser Beams," IEEE Photonics Technology Letters, Vol. 5, pp. 184-186, 1993.

[3]H. Yoda and K. Shiraiishi, "A New Scheme of a Lensed Fiber Employing a Wedge-Shaped Graded-Index Fiber Tip for the Coupling Between High-Power Laser Diodes and Single-Mode Fibers," Journal of Lightwave Technology, Vol.19, pp. 1910-1917, 2001.

[4]R. A. Modavis and T. W. Webb, "Anamorphic Microlens for Laser Diode to Single-Mode Fiber Coupling," IEEE Photonics Technology Letters, Vol.7, pp. 798-800, 1995.



Tool of Microlens Fabrication

Tool

Microlens



Ultra Tec (USA)

Sculpted End Examples



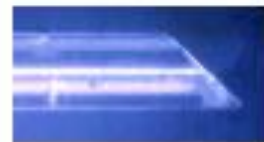
Large included-angle tapers



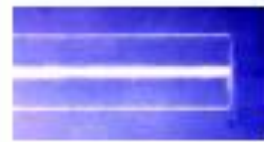
Small include d-angle tapers



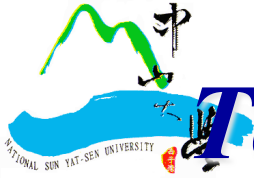
Chisel / screwdriver tips



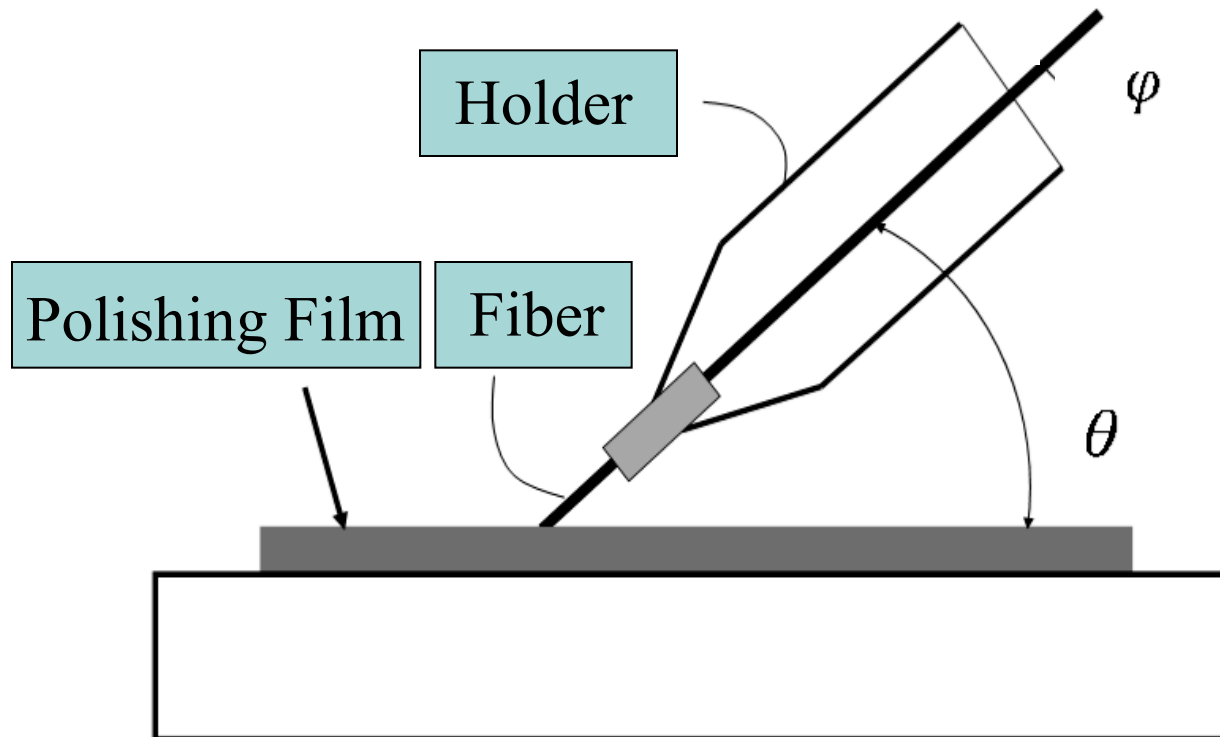
Bevels



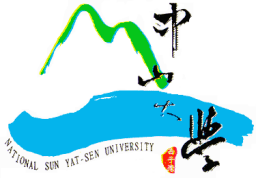
Flat Ends



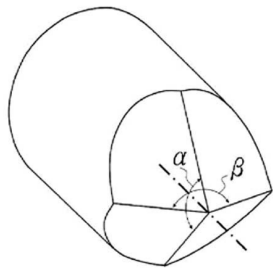
Tool Controlled by two Parameters



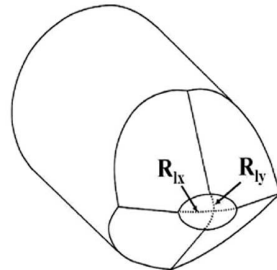
θ : Inclination Angle , ϕ : Rotation Angle



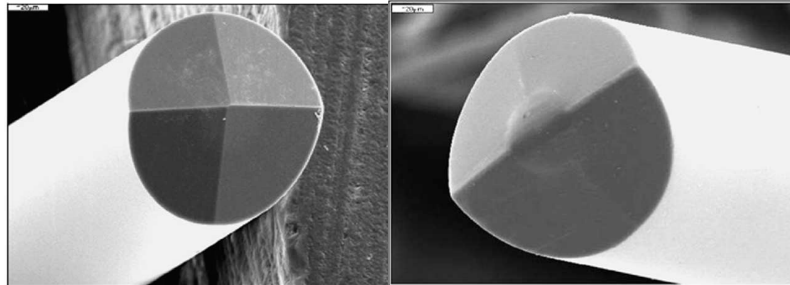
Four-Step Grinding Processes: Quadrangular-Pyramid-Shaped Fiber Endface (QPSFE)



(a)



(a)



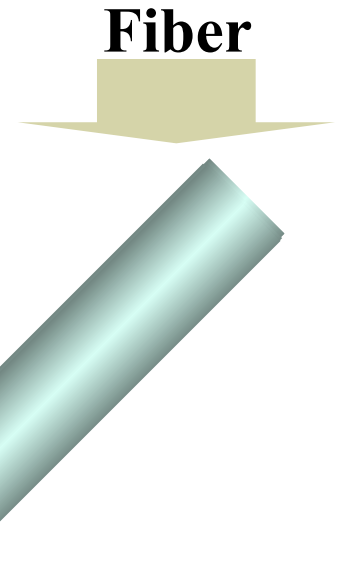
(b)

(b)

Lift up, Rotate 180°

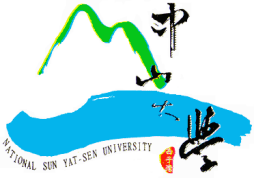
Step:4

Polishing Film



Fiber

1. Yeh S.M., Lu Y.K., Huang S.Y., Lin H. H., Hsieh C. H., and **Cheng W.H.**, "A Novel Scheme of Lensed Fiber Employing a Quadrangular-Pyramid-Shaped Fiber Endface for Coupling Between High-Power Laser Diodes and Single-Mode Fibers," *Journal of Lightwave Technology*, 22, 1374.(2004)



Components

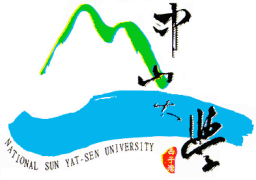
- Laser Chips

Divergence Angles = $8^\circ \times 40^\circ$ (aspect ratio: 1:5)

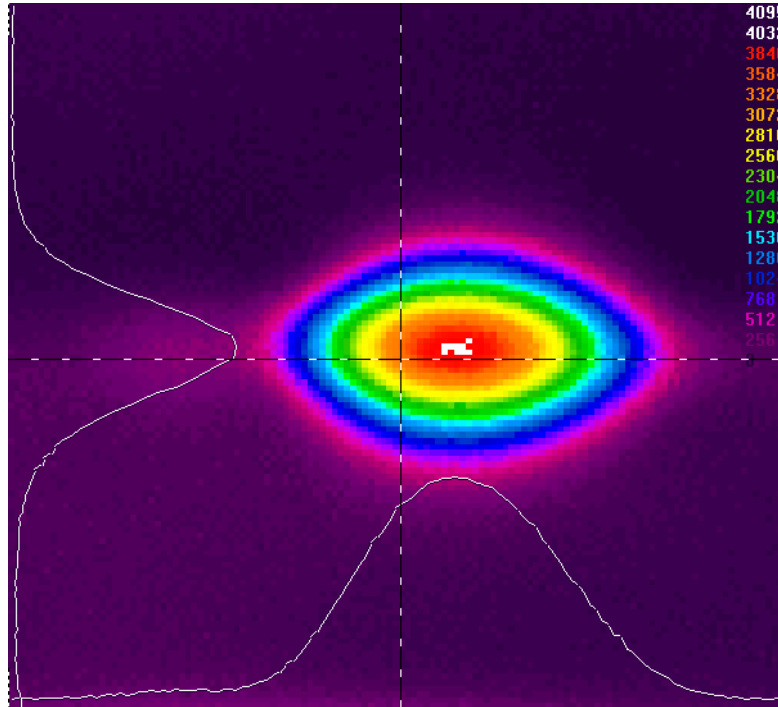
($W_{x0} = 2.6\mu\text{m}$, $W_{y0} = 0.5\mu\text{m}$)

- SMFs

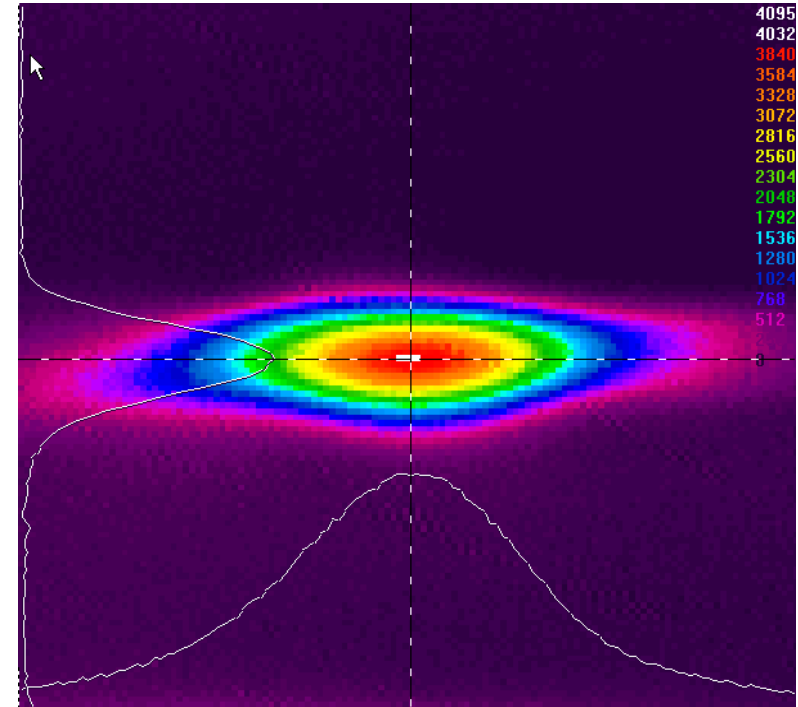
$\text{MFD}_1 = 4.0\mu\text{m}$, $\text{MFD}_2 = 5.7\mu\text{m}$



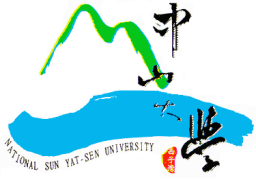
Far-Field Pattern of QPSFE



Aspect Ratio = 1 : 2.4
($\eta = 44\%$)

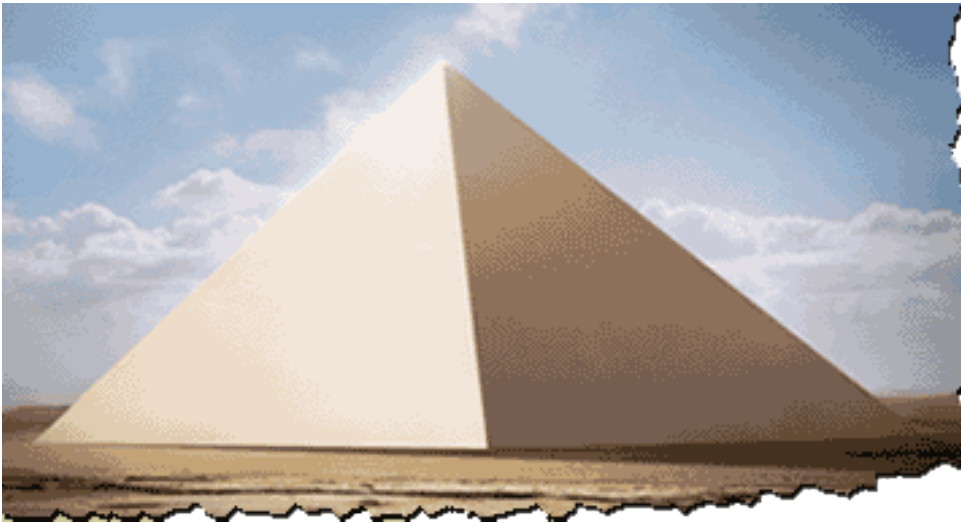


Aspect Ratio = 1 : 3.9
($\eta = 83\%$)

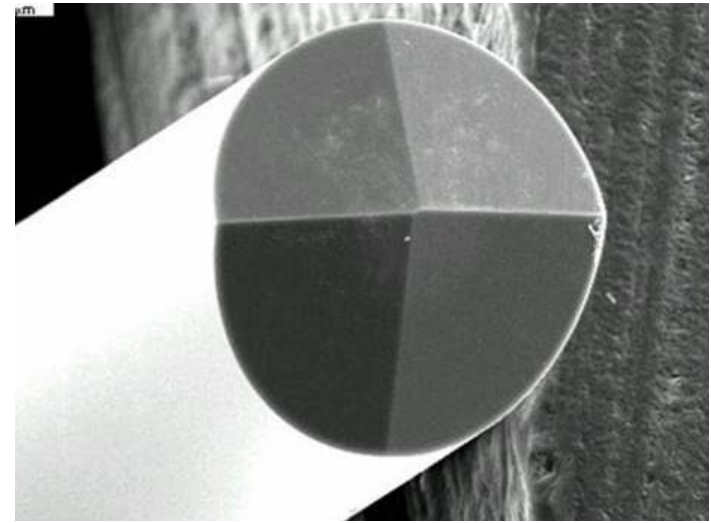


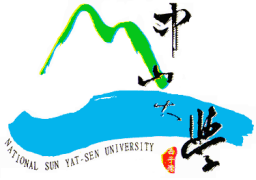
Pyramid

The Pyramids of Egypt

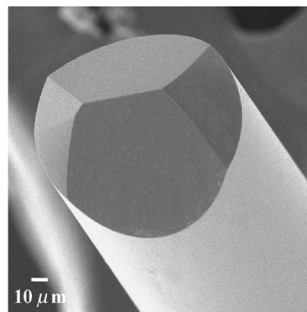
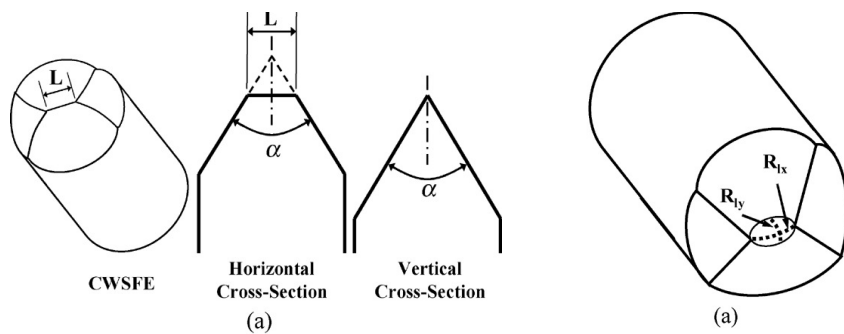


QPSFE
Quadrangular-
Pyramid-Shaped
Fiber Endface

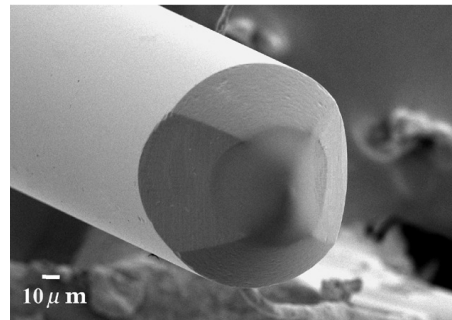




Three-Step Grinding Process: Conical-Wedge-Shaped Fiber Endface (CWSFE)

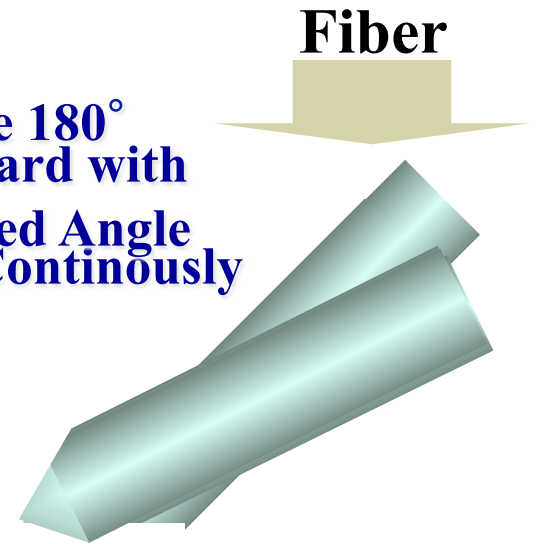


(a)



(b)

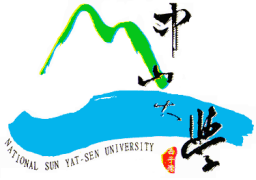
**Lift up, Rotate 180°
Stress Downward with
Smaller Inclined Angle
Rotate 360° Continuously**



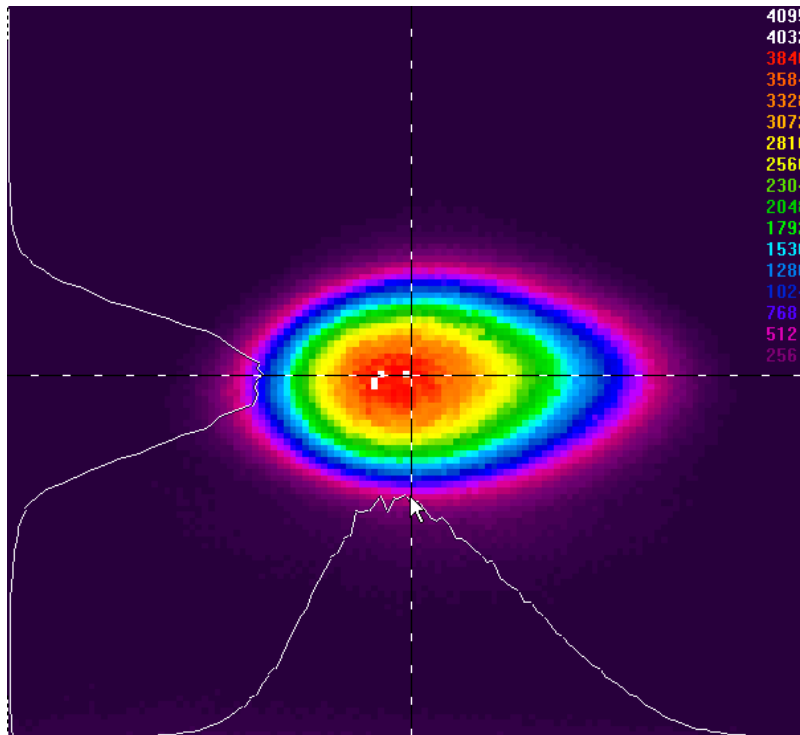
Step:3

Polishing Film

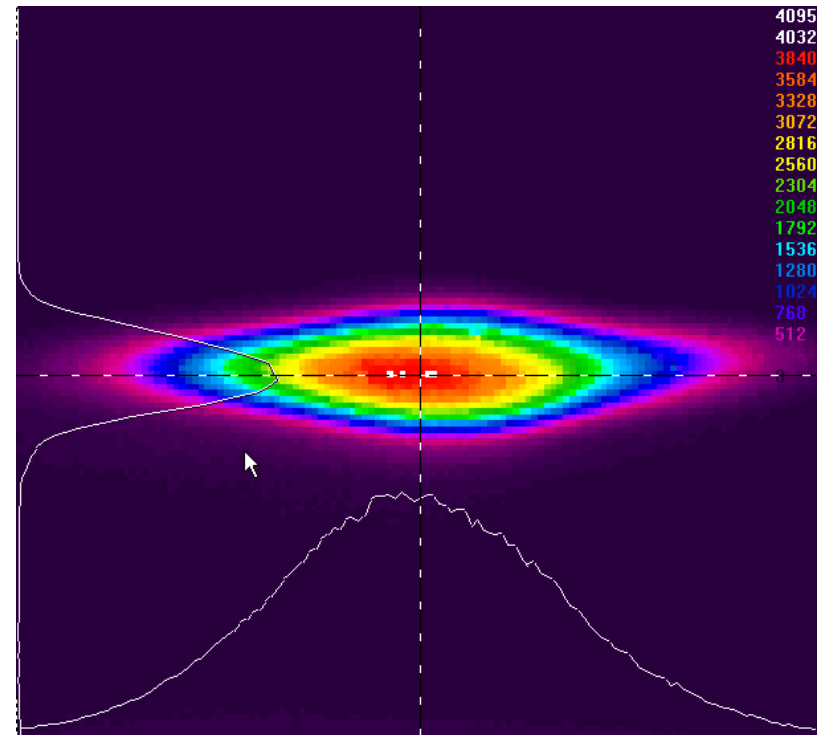
1. Yeh S. M., Huang S. Y. and Cheng W. H., "A new scheme of conical-wedge-shaped fiber endface for coupling between high-power laser diodes and single-mode fibers," *Journal of Lightwave Technology*, 23, 1781.(2005).
2. US patent 7515789 (2009) , 7295729 (2007) , Conical-wedge-shaped lensed fiber and the method of making the same



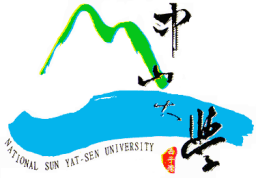
Far-Field Pattern of CWSFE



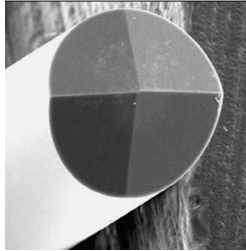
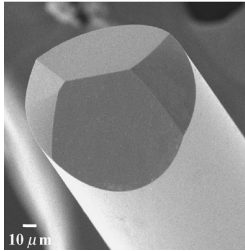
Aspect Ratio = 1 : 1.7
($\eta = 61\%$)

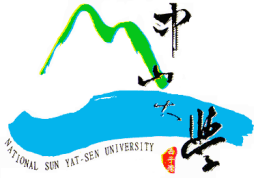


Aspect Ratio = 1 : 3.8
($\eta = 84\%$)



Comparison Structures of QPSFE and CWSFE

	QPSFE	CWSFE
Shape		
Grinding step	4	3
Range/average offset (μm)	2.3/1.5	1.2/0.9
Max. Coupling Efficiency	83%	84%
Advantage	High coupling efficiency.	High coupling efficiency, Less grinding step.
Disadvantage	Low yield due to multi-step grinding processes, requires fusing process.	Low yield due to multi-step grinding processes, requires fusing process.



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3. Second Generation Microlens

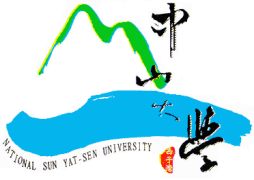
Two-Electrical Torques Control

4. Third Generation Microlens

Three-Electrical Torques Control

5. Near-Field Measurements

6. Conclusion



Single-Step Grinding Technique

First generation of microlens (G1)

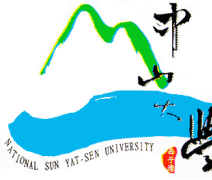
One-mechanical torque control incline angle (θ) and rotation angle (ϕ).

Second generation of microlens (G2)

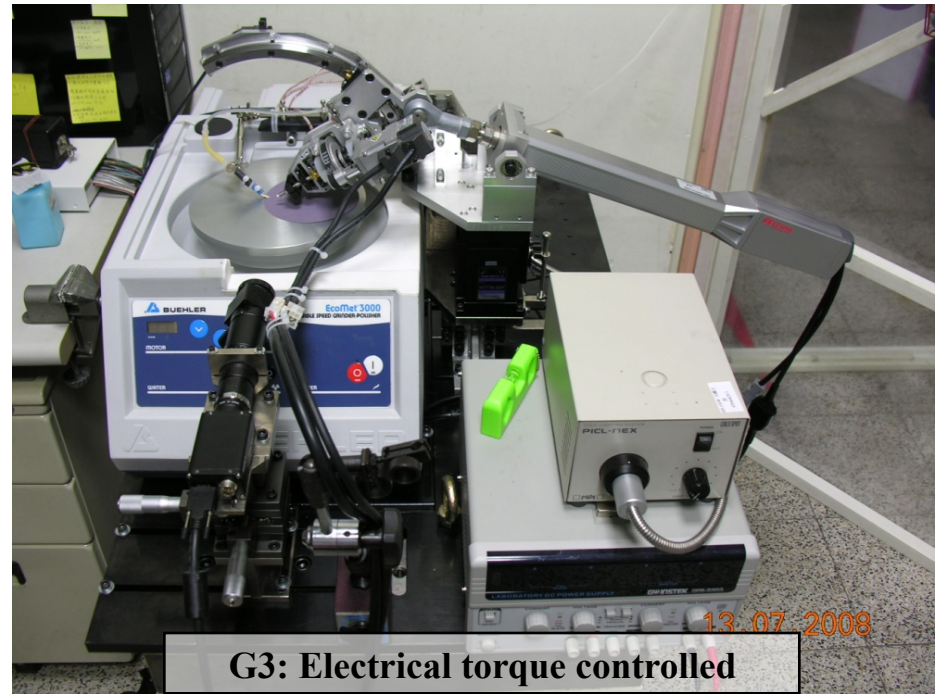
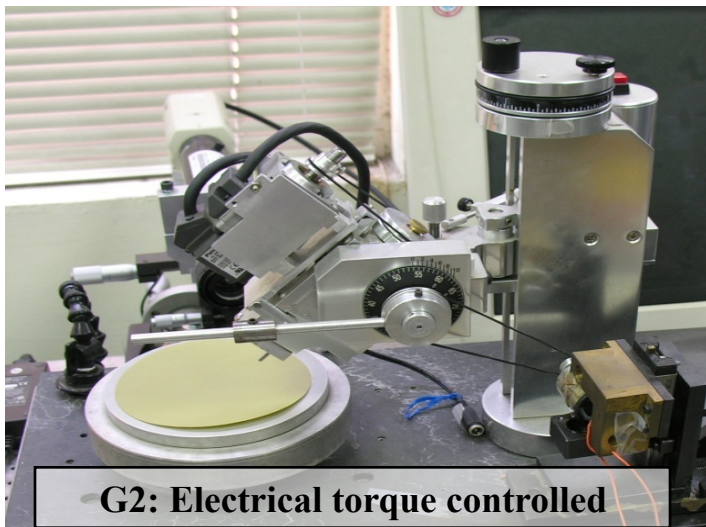
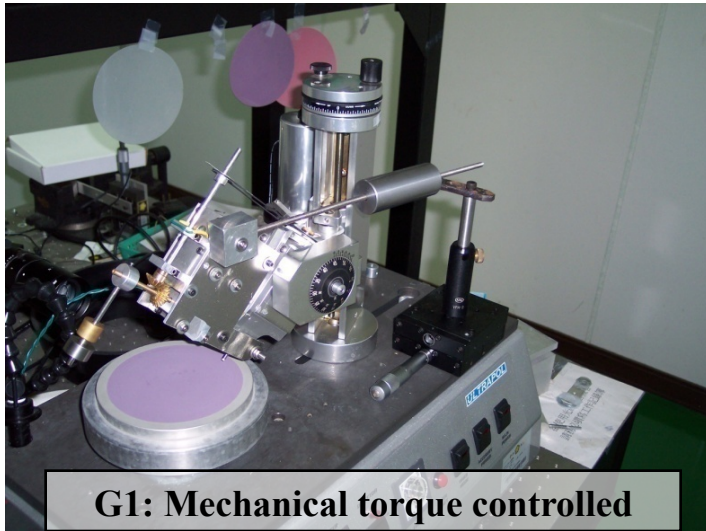
Two-electrical torques control incline angle (θ) and rotation angle (ϕ).

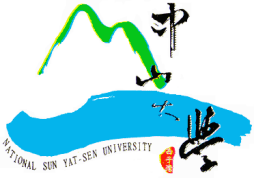
Third generation of microlens (G3)

Three-electrical torques control incline angle (θ), rotation angle (ϕ), and contact height (H).



Tool of Single-Step Grinding Process





Formation Principle of Asymmetric Endface

- According to Preston's equation, the material removal rate (dT/dt) can be represented as:

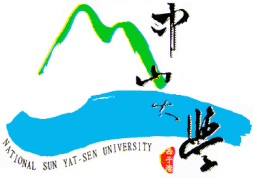
$$\frac{dT}{dt} = K \frac{N}{A} \frac{dS}{dt}$$

- $\frac{dT}{dt} = R$ (Material Removal Rate)

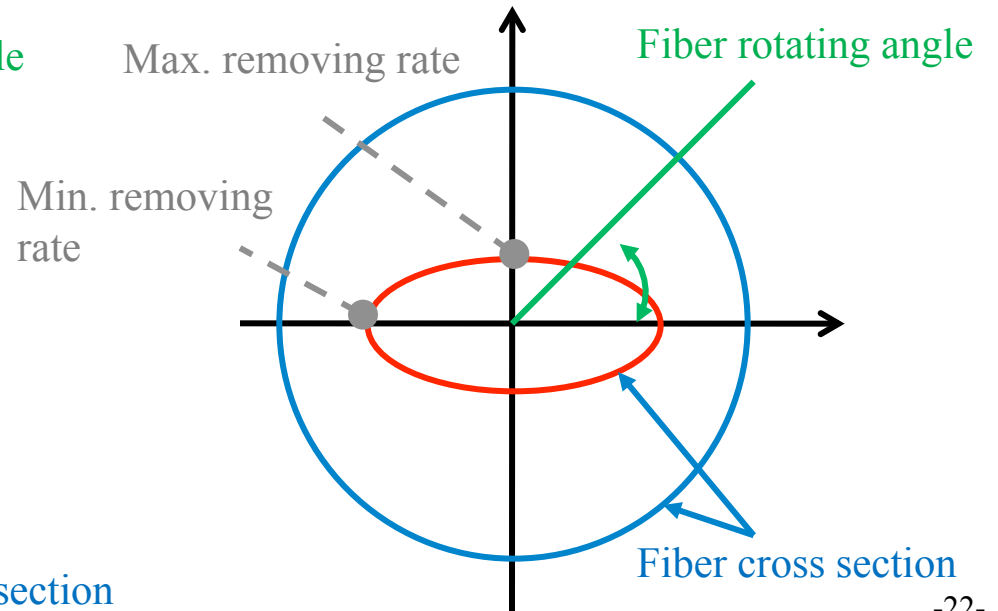
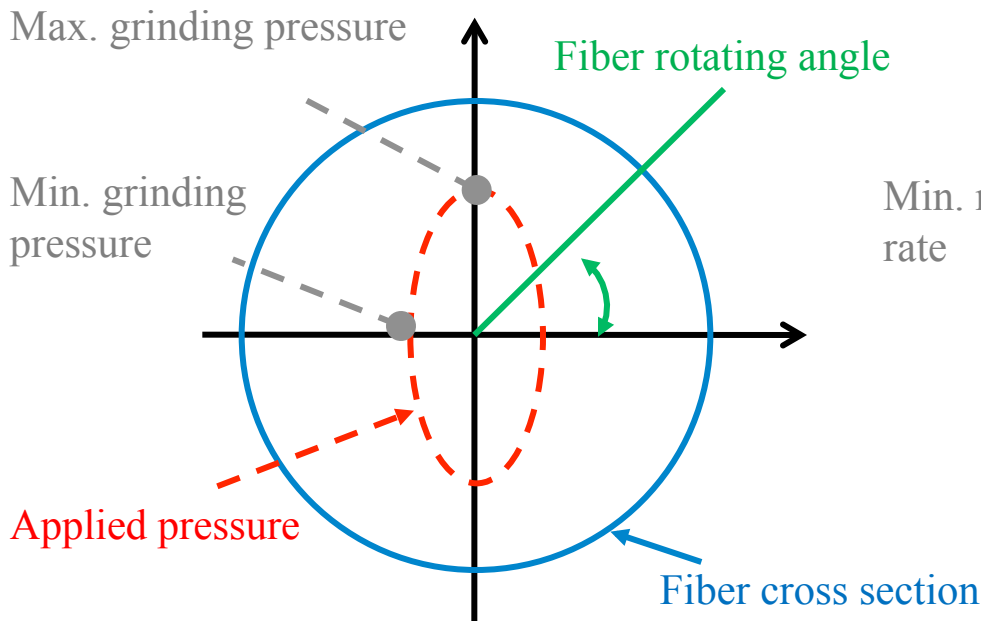
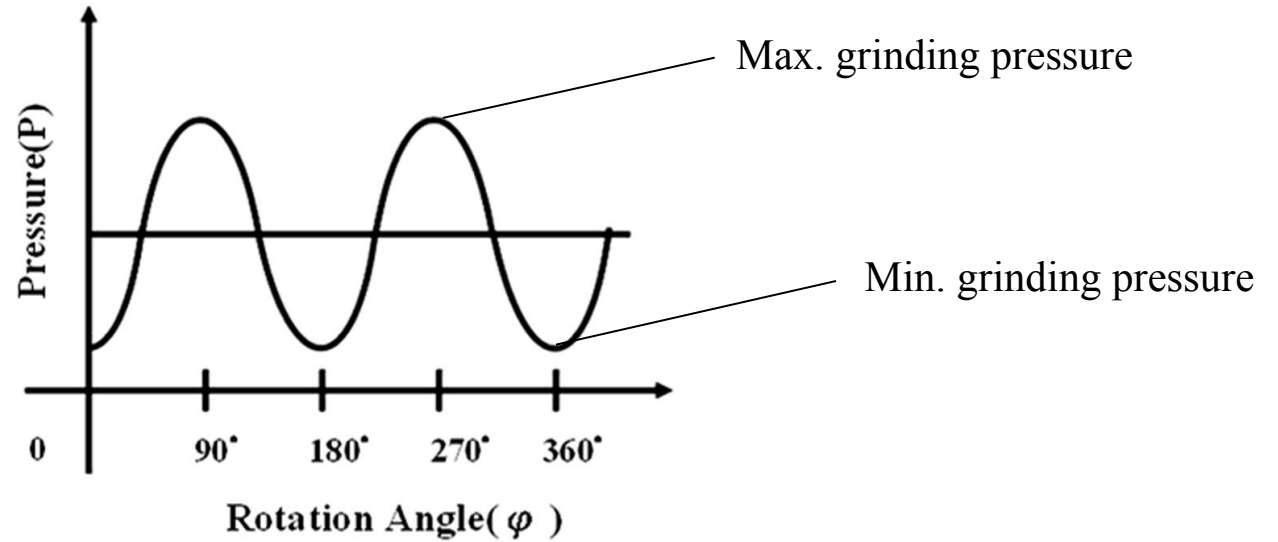
- $\frac{N}{A} = P$ (Normal Pressure)

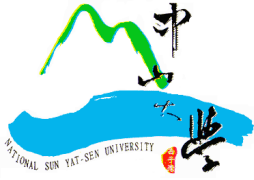
- $\frac{dS}{dt} = V$ (Relative Velocity)

$$R = KPV$$

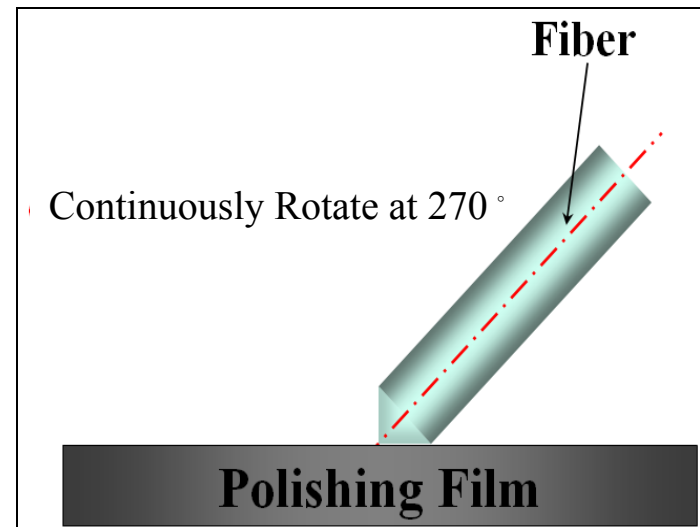
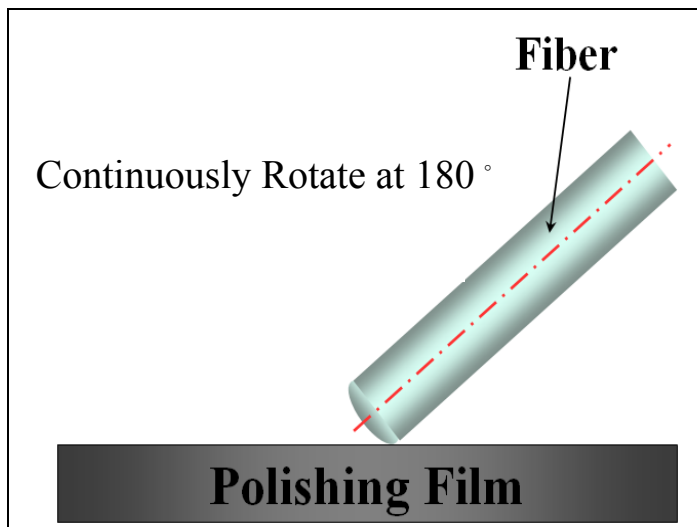
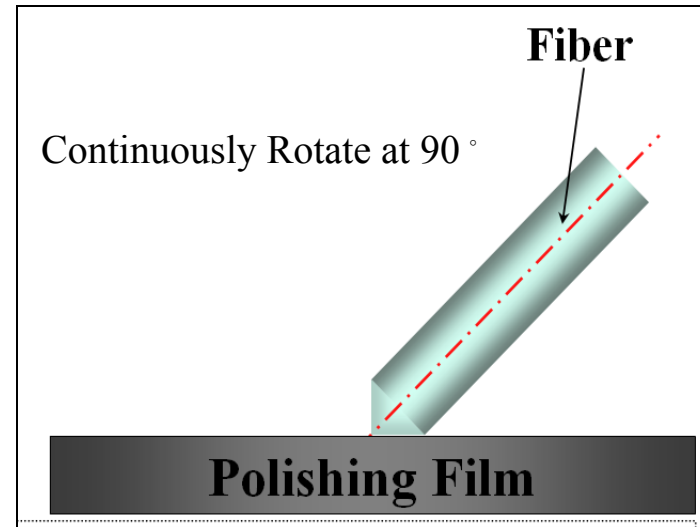
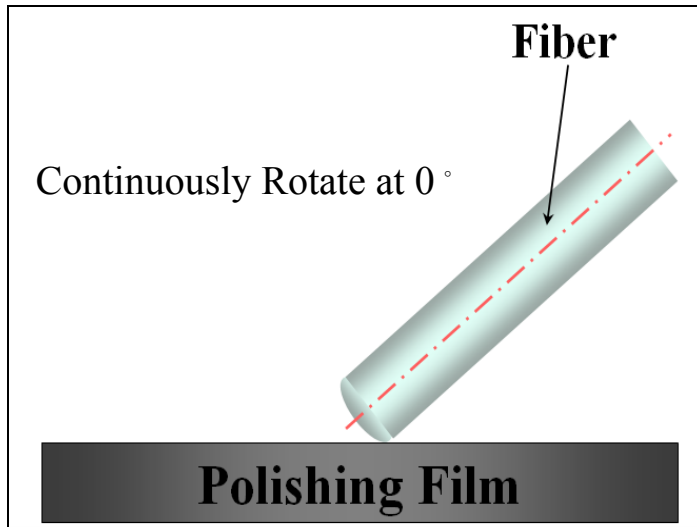


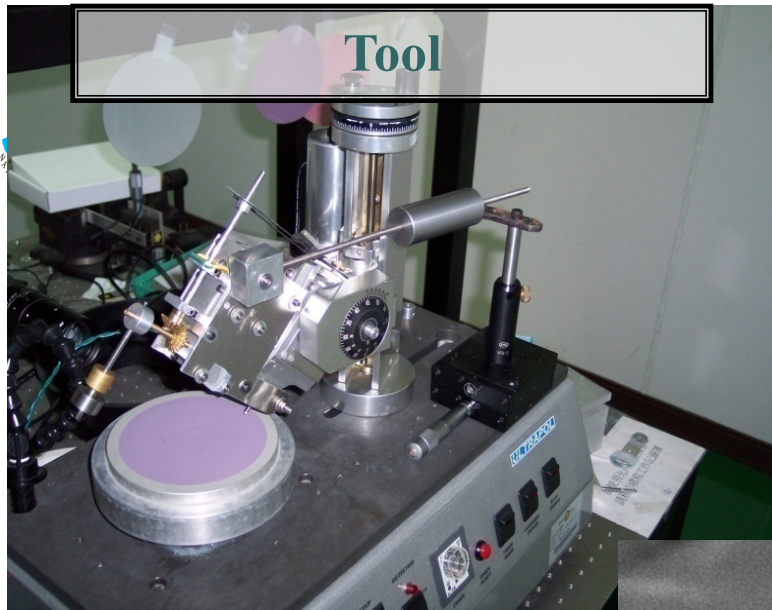
Formation of Asymmetric Fiber Endface





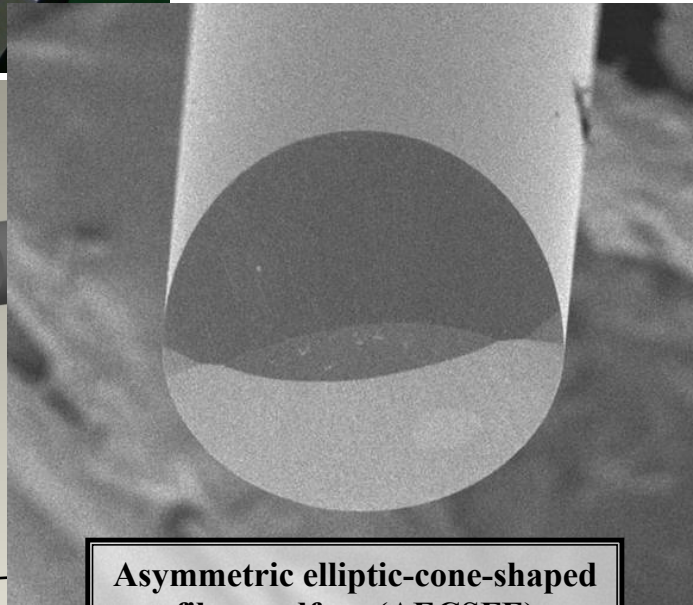
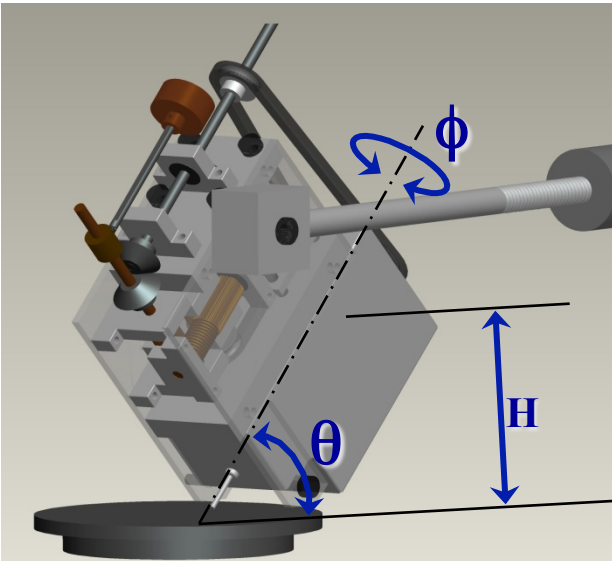
GI: One-Mechanical Torque Controlled



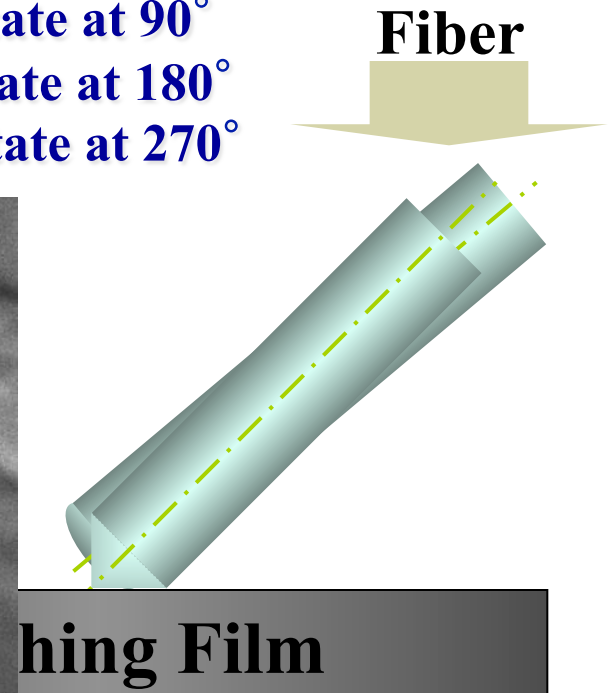


G1 – One-Mechanical Torque Controlled (AECSFE)

Continuously Rotate at 0°
 Continuously Rotate at 90°
 Continuously Rotate at 180°
 Continuously Rotate at 270°

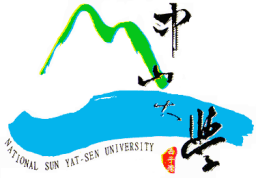


Asymmetric elliptic-cone-shaped fiber endface (AECSFE)

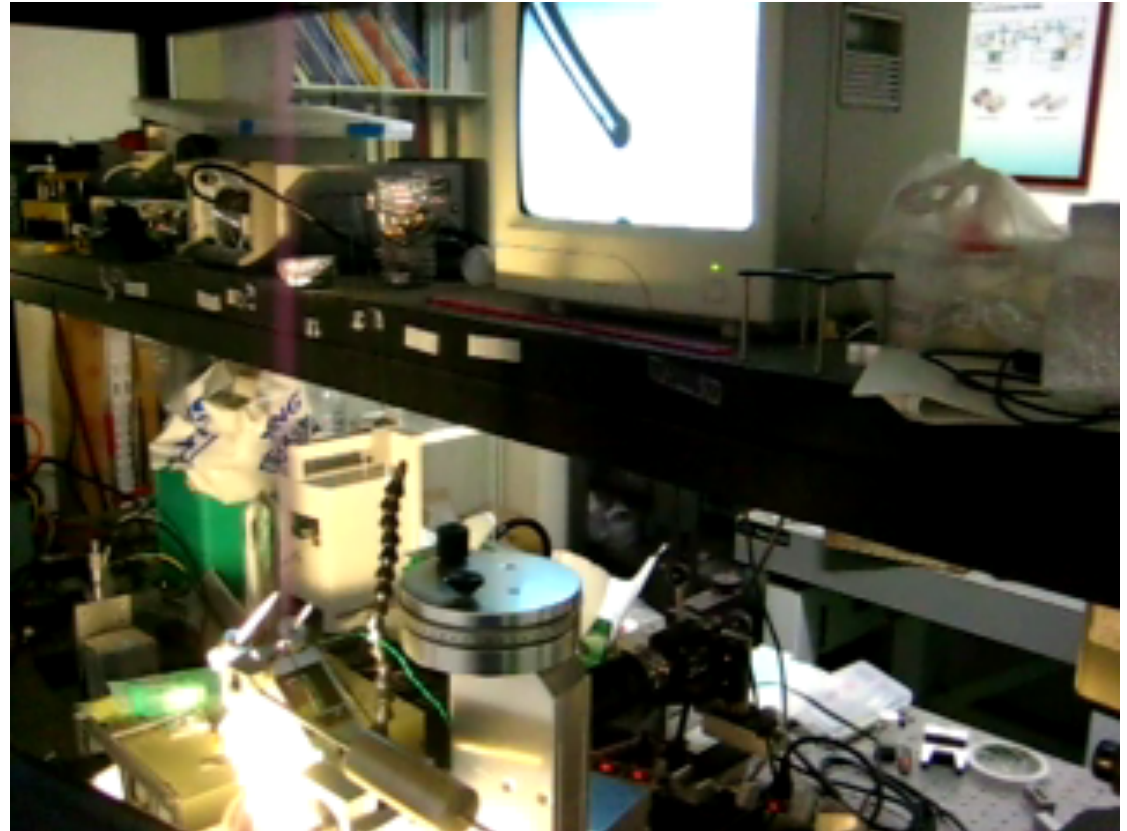
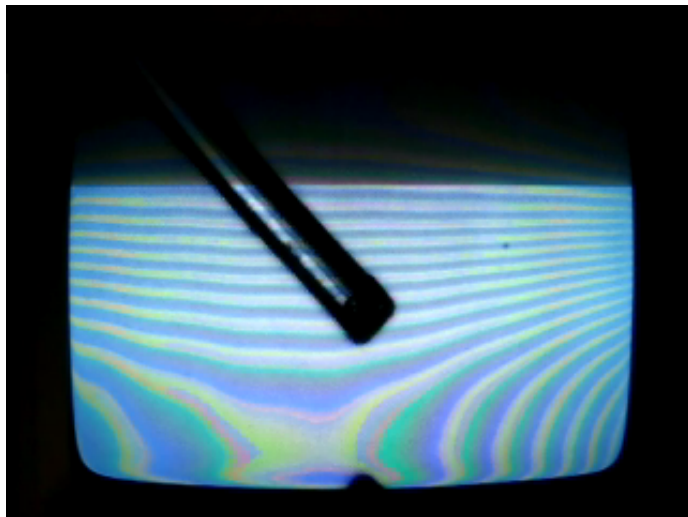
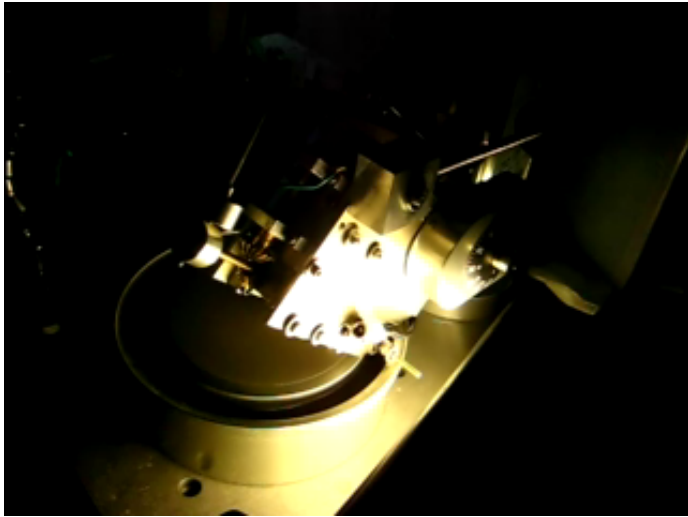


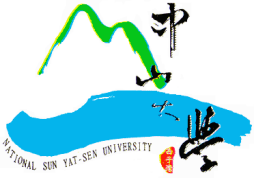
ϕ variable (H & θ dependent on ϕ)

1. Yu-Kuan Lu, Ying-Chien Tsai, Yu-Da Liu, Szu-Ming Yeh, Chi-Chung Lin, and **Wood-Hi Cheng**, "Asymmetric elliptic cone-shaped microlens for efficient coupling to high-power laser diodes," *Optics Express*, 15, 1434 (2007).
2. US patent : 7494399 , Single-step fiber grinding process and apparatus

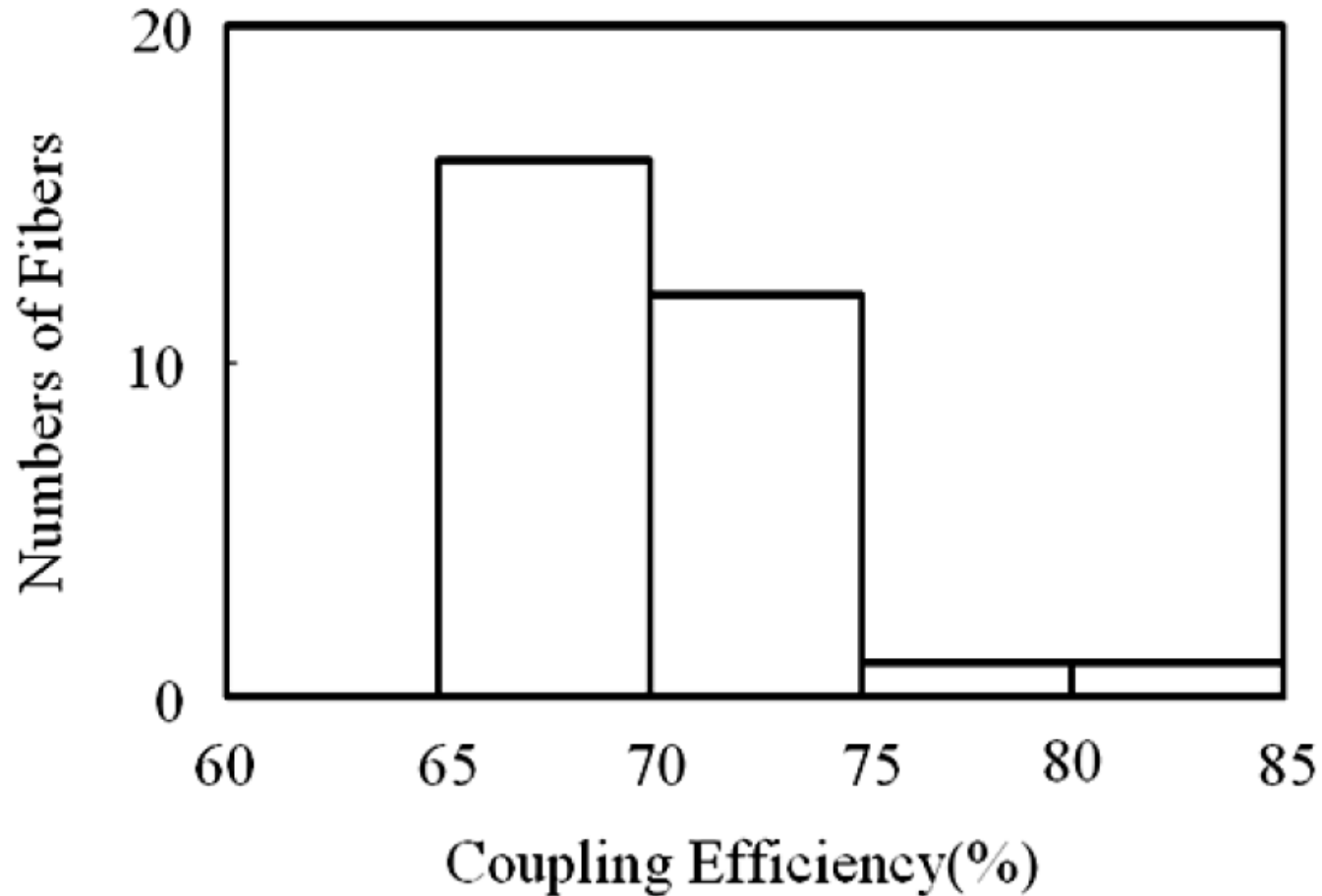


G1 – One-Mechanical Torque Controlled AECSEFE Fabrication

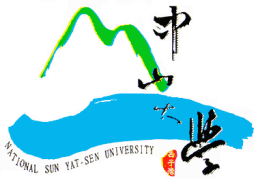




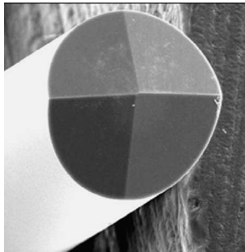
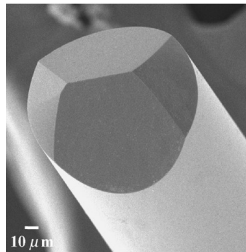
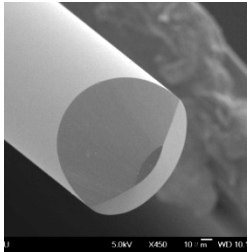
Histogram of measured coupling efficiencies between 980-nm laser diode and AECSFE

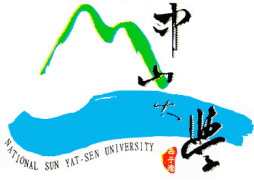


Average coupling efficiency = 71%



Comparison Structures of Asymmetric Fiber Endface (QPSFE, CWSFE, AESFE)

	QPSFE	CWSFE	AESFE
Shape			
Grinding step	4	3	1
Range/average offset (μm)	2.3/1.5	1.2/0.9	0.8/0.4
Max Coupling Efficiency	83%	84%	85%
Advantage	High coupling efficiency.	High coupling efficiency.	Single-step grinding technique. High yield and high coupling efficiency.
Disadvantage	Low yield due to multi-step grinding processes	Low yield due to multi-step grinding processes.	Low aspect ratio.



Outline

1. Motivation and Review

2. First Generation Microlens

One-Mechanical Torque Control

3. Second Generation Microlens

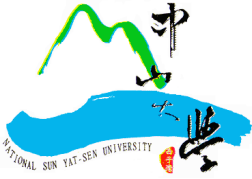
Two-Electrical Torques Control

4. Third Generation Microlens

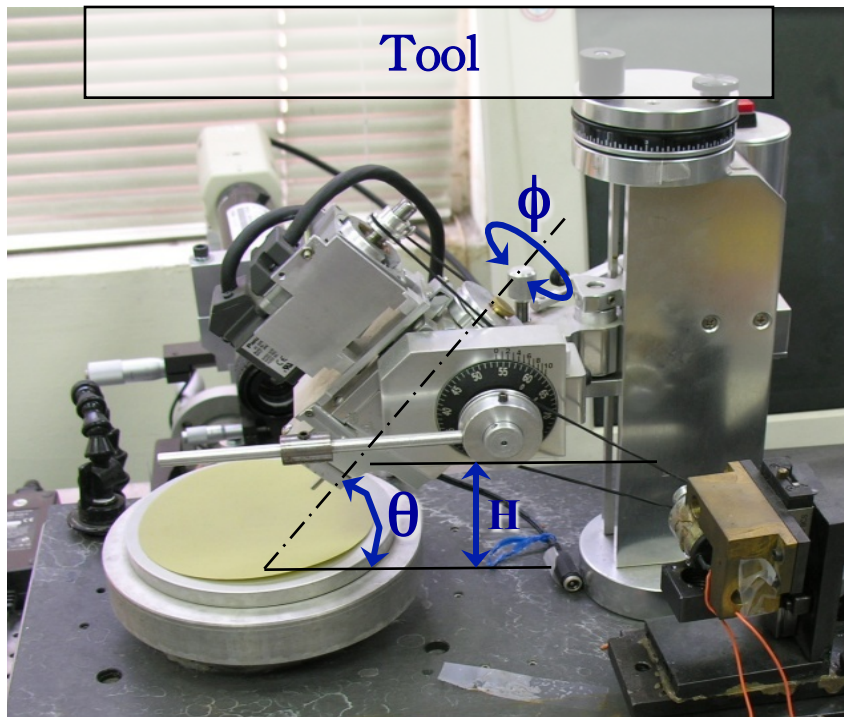
Three-Electrical Torques Control

5. Near-Field Measurements

6. Conclusion



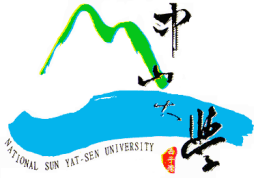
G2 – Two-Electrical Torque Controlled



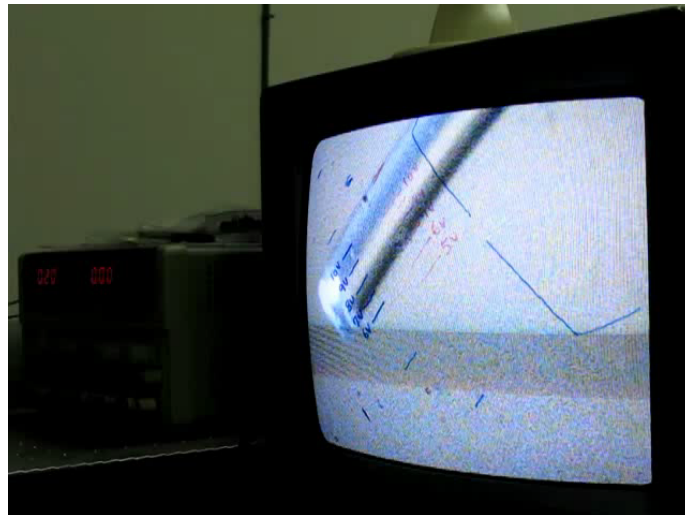
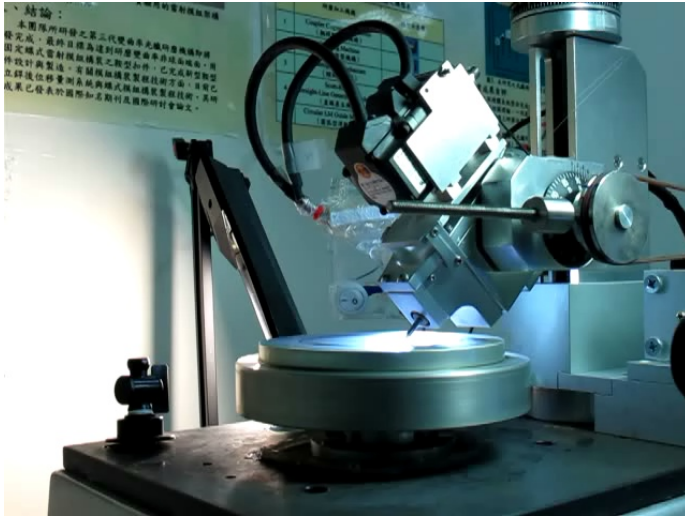
- Advantages :
1. Curvature with high aspect ratio
 2. Different shapes of endface

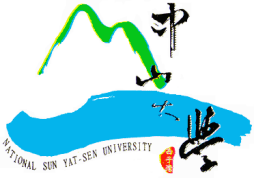
H constant, θ & ϕ variables

1. Tsai Y.C., Liu Y.D., Cao C.L., Lu Y.K. and **Cheng W.H.**, “A new scheme of fiber end-face fabrication employing a variable torque technique,” *Journal of Micromechanics and Microengineering*, 18, 055003.1-055003.7. (2008)

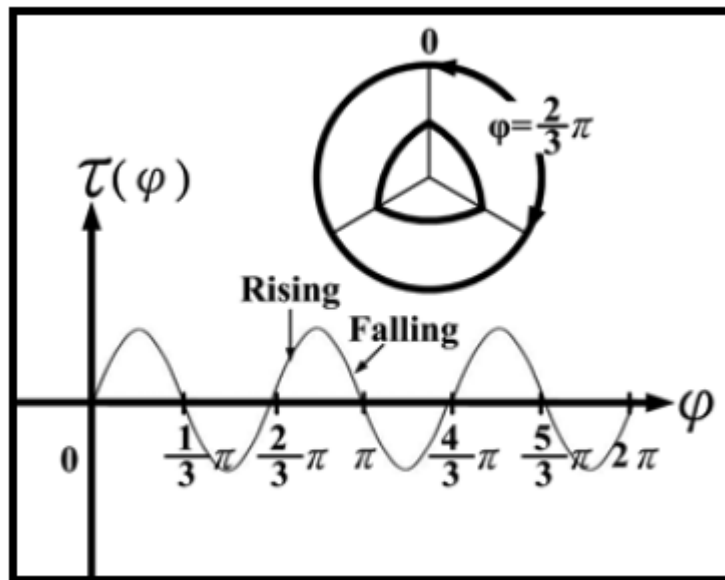


G2 – Two-Electrical Torques Controlled



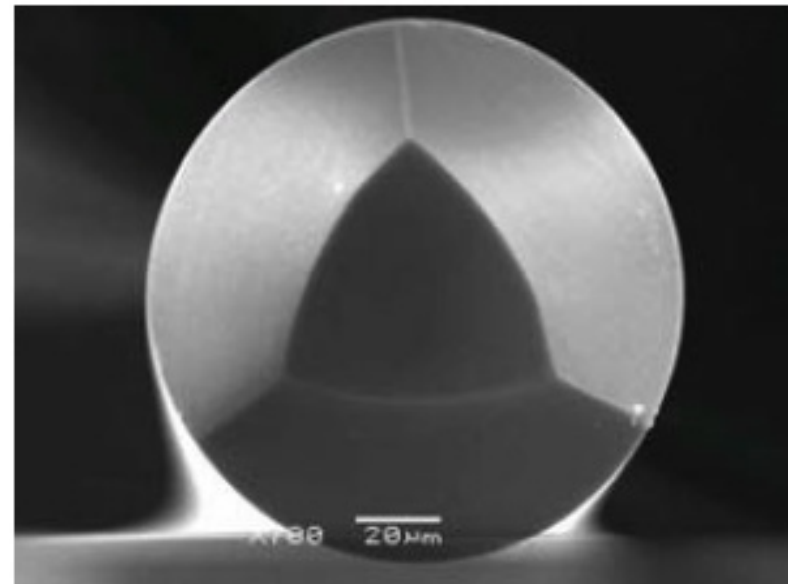


Torque Application of the Sinusoidal Wave Input and its Endface Output



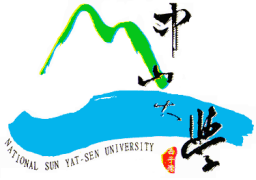
(a)

Relationship between the torque and its expected end-face.

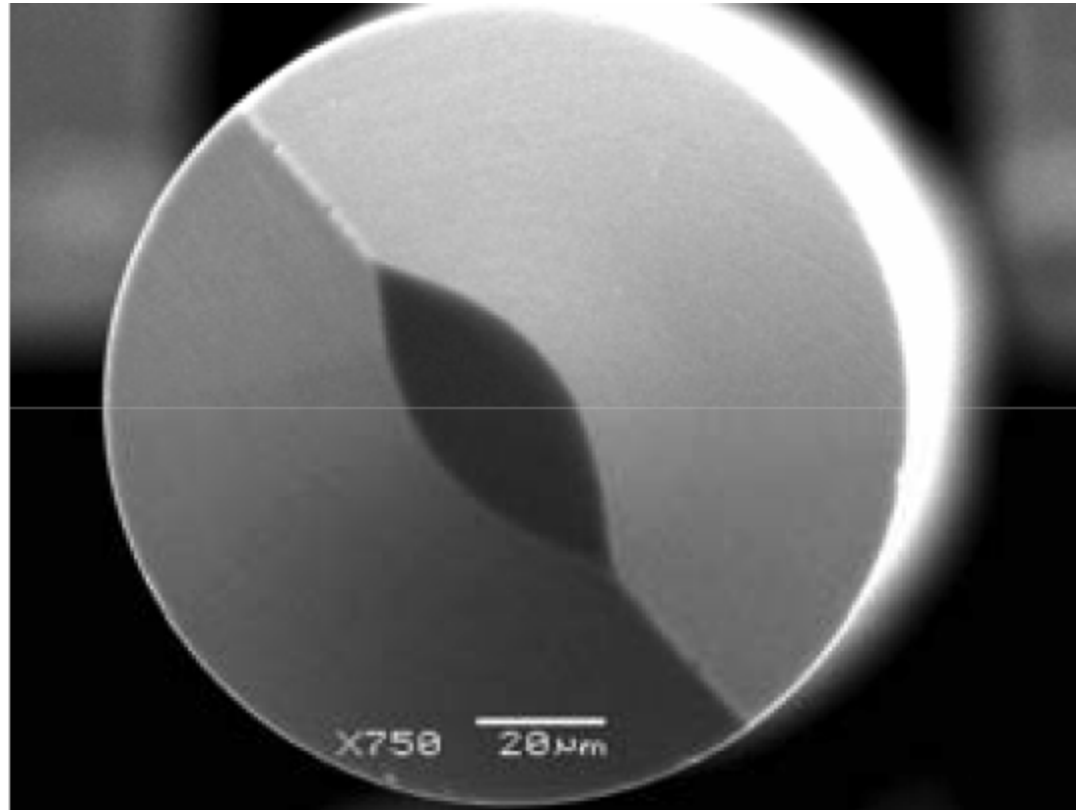


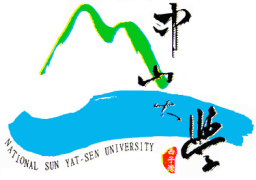
(b)

SEM of the finished model.

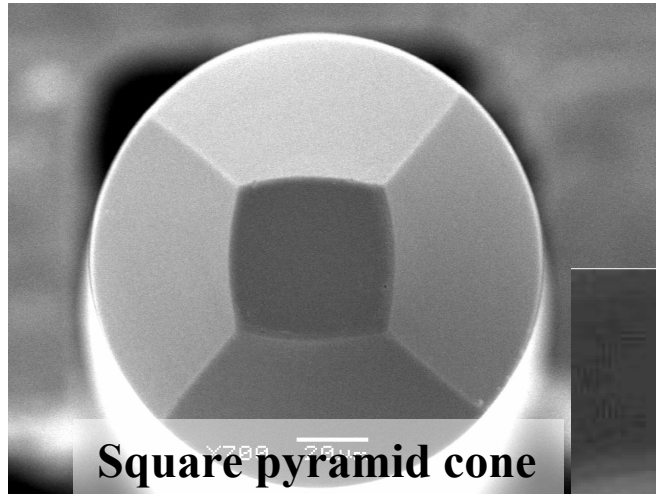


Asymmetric Elliptic-Cone-Shaped Microlens (AECSM)

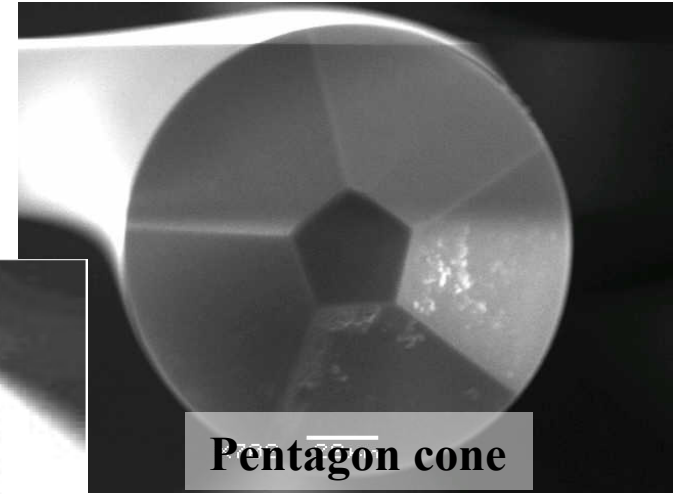




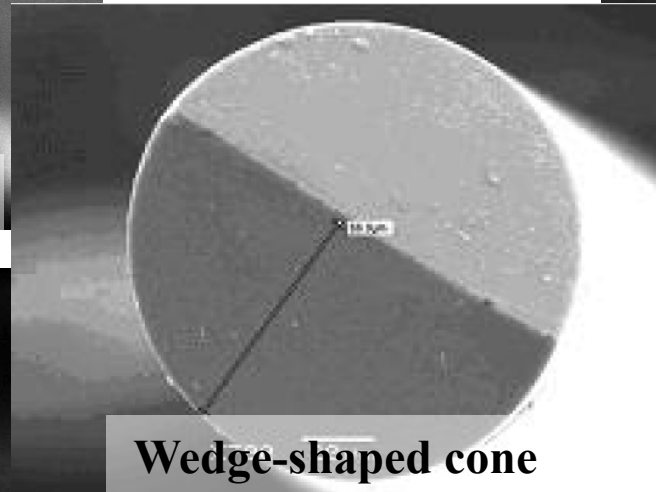
Different Shapes of Endface (Artwork Microlens)



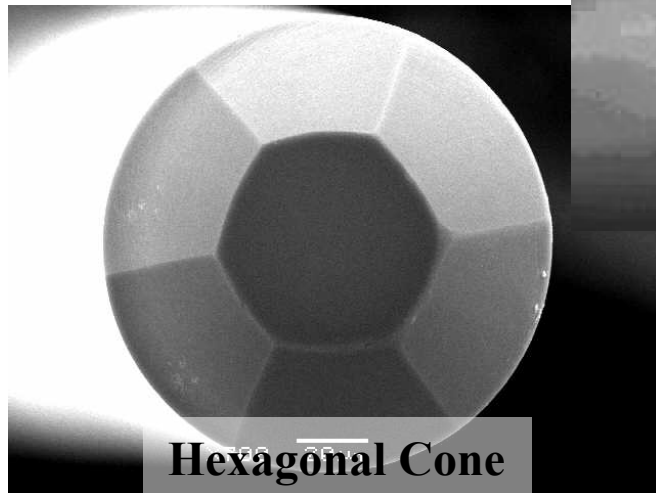
Square pyramid cone



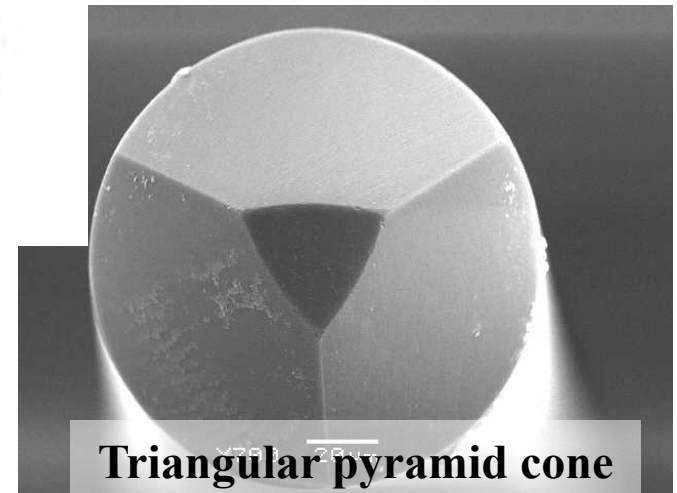
Pentagon cone



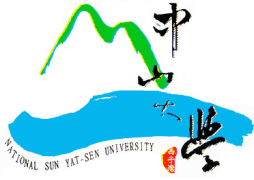
Wedge-shaped cone



Hexagonal Cone



Triangular pyramid cone



Outline

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2. First Generation Microlens

One-Mechanical Torque Control

3. Second Generation Microlens

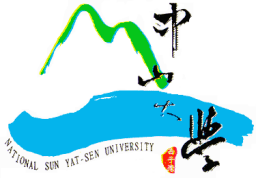
Two-Electrical Torques Control

4. Third Generation Microlens

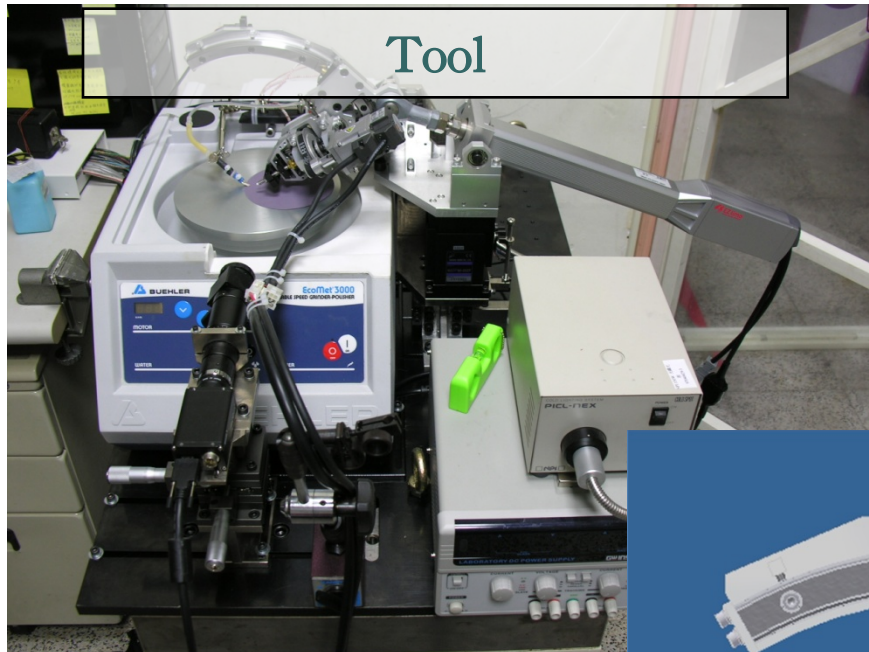
Three-Electrical Torques Control

5. Near-Field Measurements

6. Conclusion

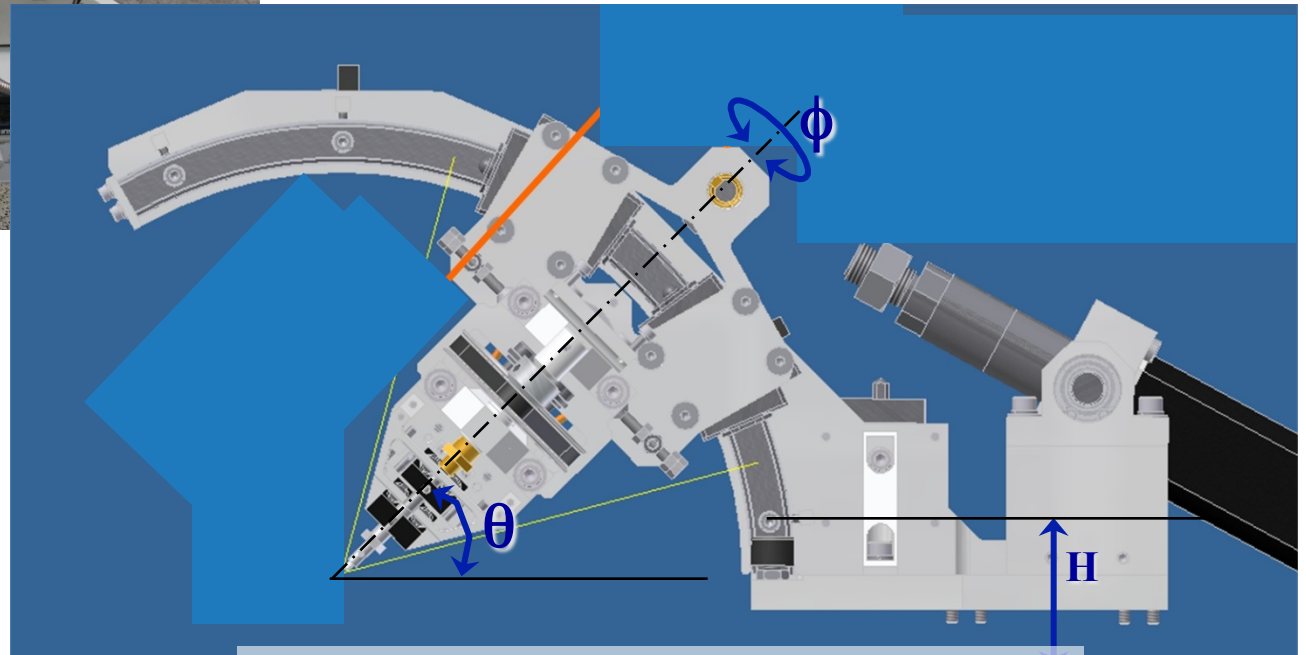


G3 – Three-Electrical Torques Controlled

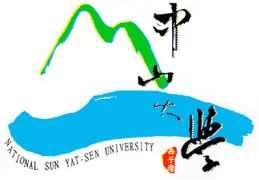


Three-electrical torques controlled incline angle (θ), rotation angle (ϕ), and contact height (H)

Advantage: Double-variable-curvature microlens Curvature. Fusion process applied only for fine polishing (not reshape).

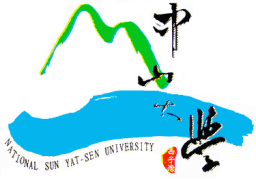


H, θ & ϕ independent variables

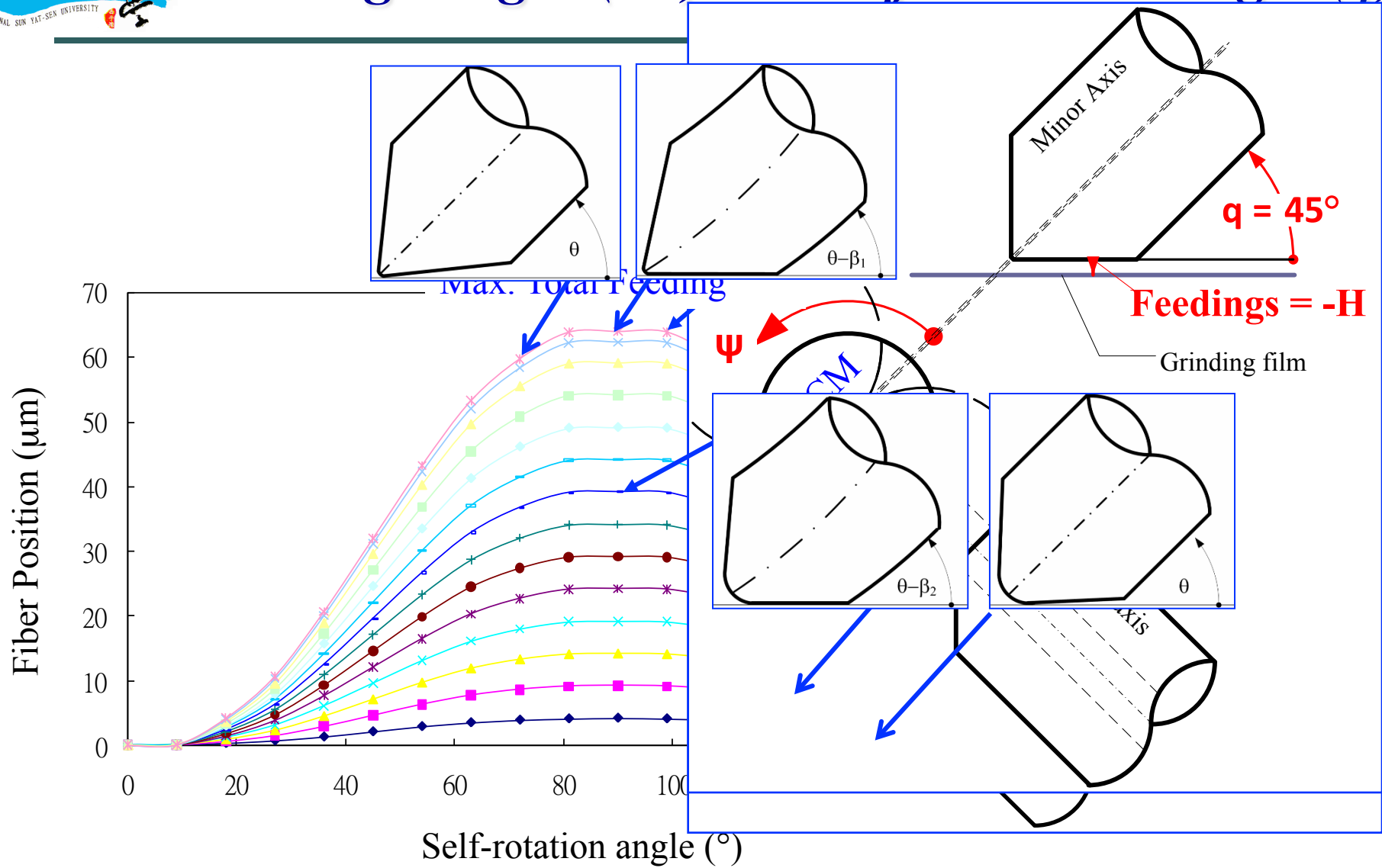


G3 – Three-Electrical Torques Controlled

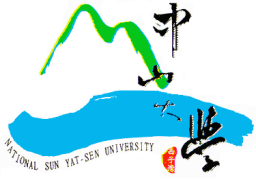




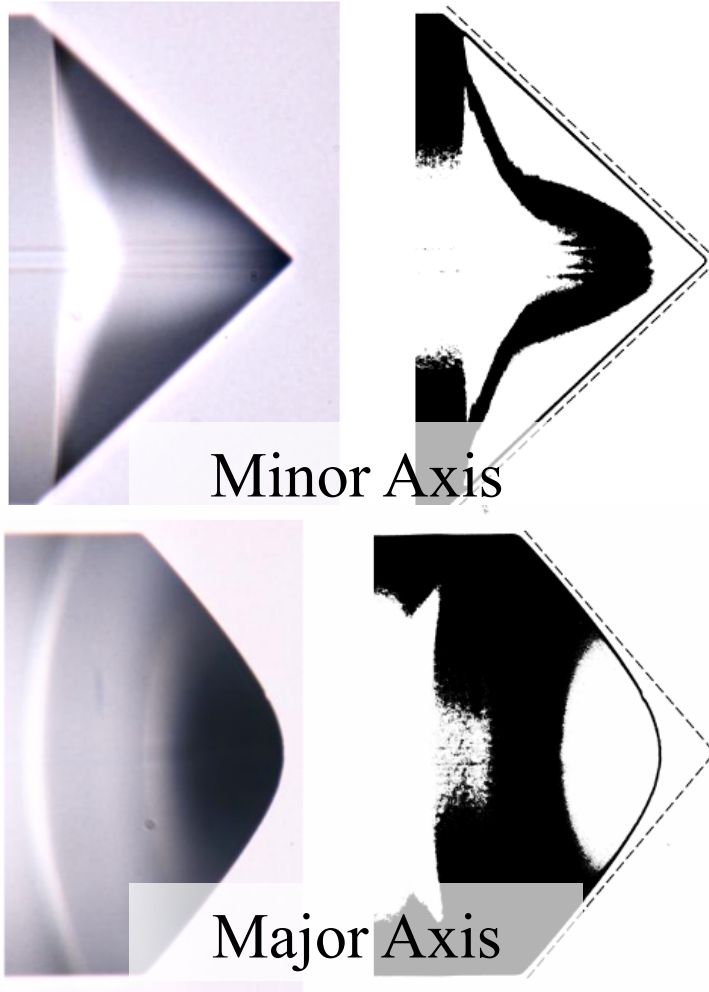
Feedings Hight (-H) v.s. Self-Rotation Angle (ϕ)



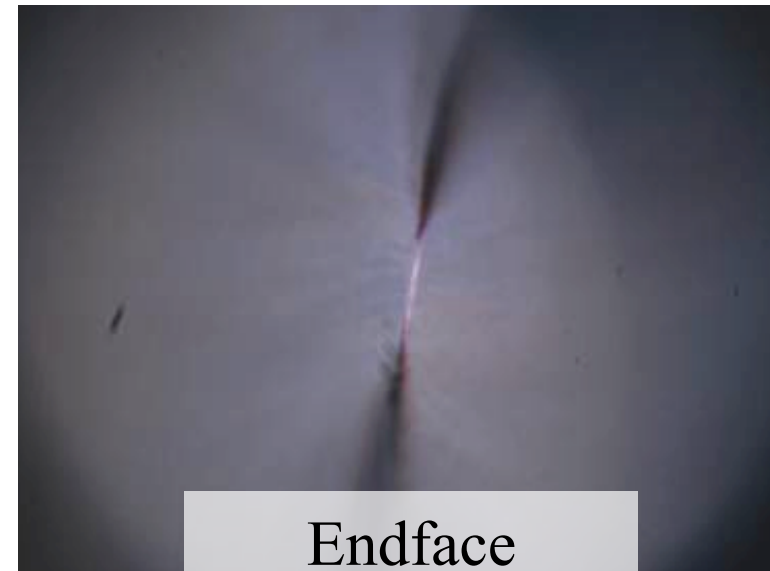
Y. D. Liu, Y. C. Tsai, L. J. Wang, Y. K. Lu, M. C. Hsieh, S. M. Yeh, and **W. H. Cheng**, "New scheme of double-variable-curvature microlens for efficient coupling high-power lasers to single-mode fibers," *Journal of Lightwave Technology*, 29, 898-904, (2011).

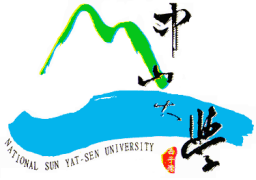


Optical Photos of Double-Variable -Curvature Fiber Endface (DVCFE)

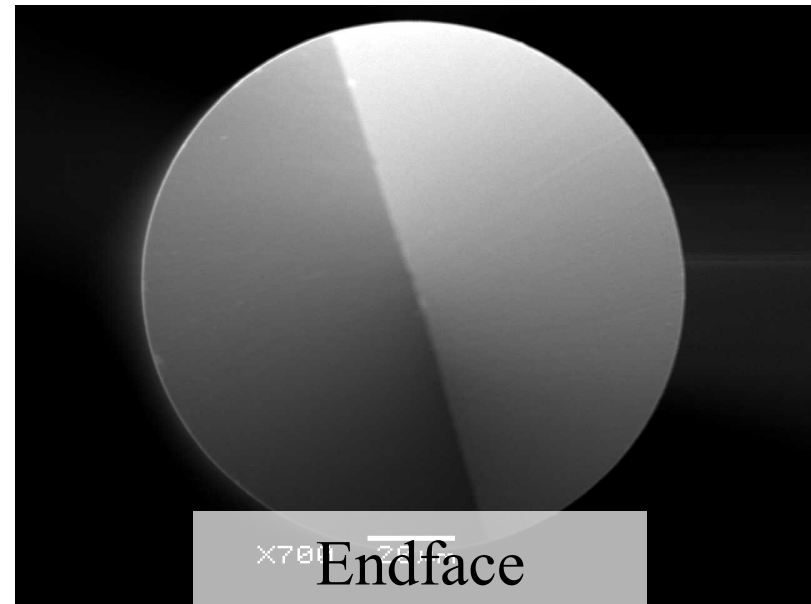
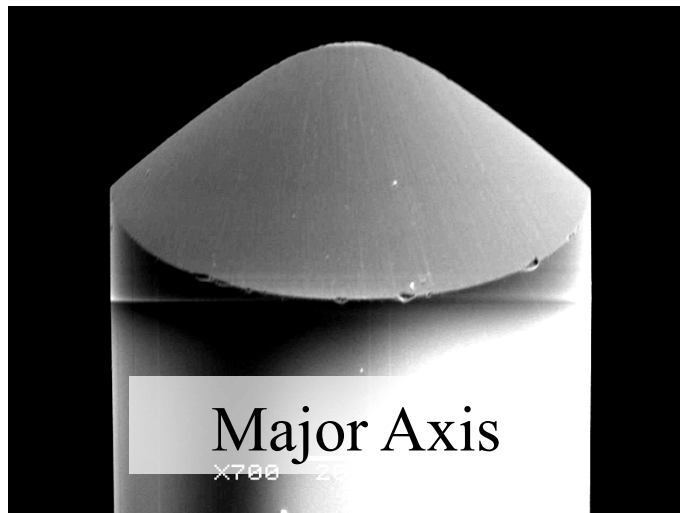


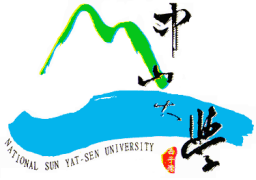
After grinding process



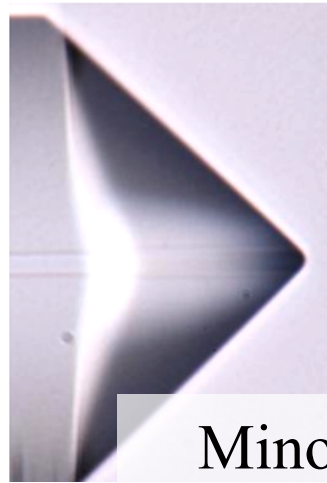


SEM of Endface (DVCFE)

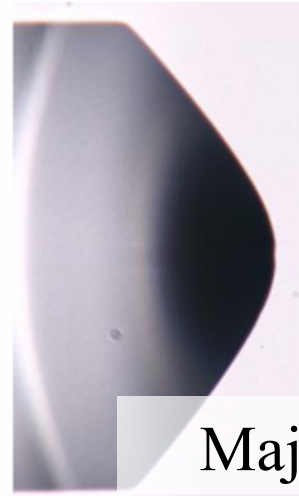




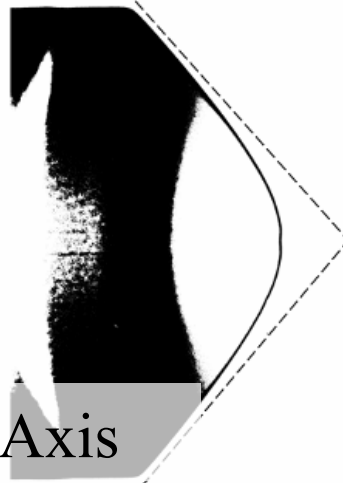
Optical Photos of Double-Variable -Curvature Microlens (DVCM)



Minor Axis



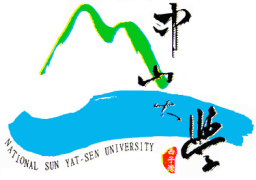
Major Axis



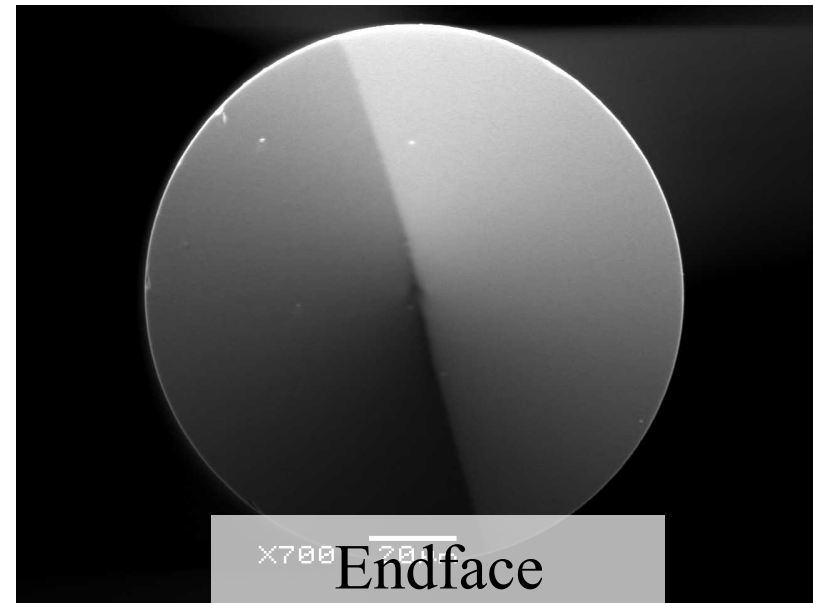
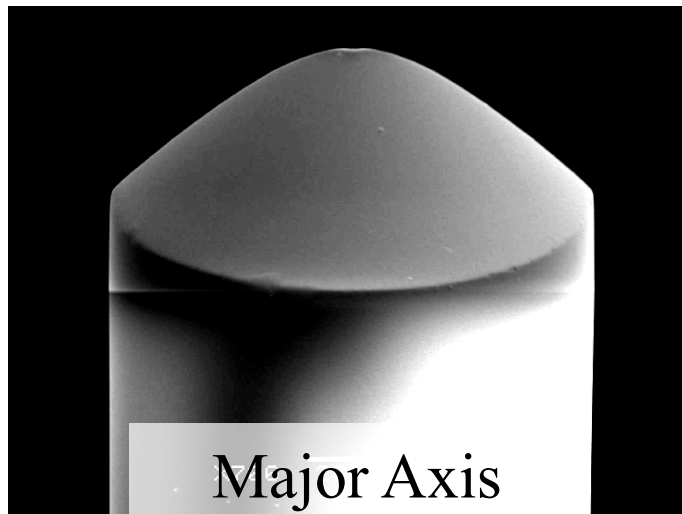
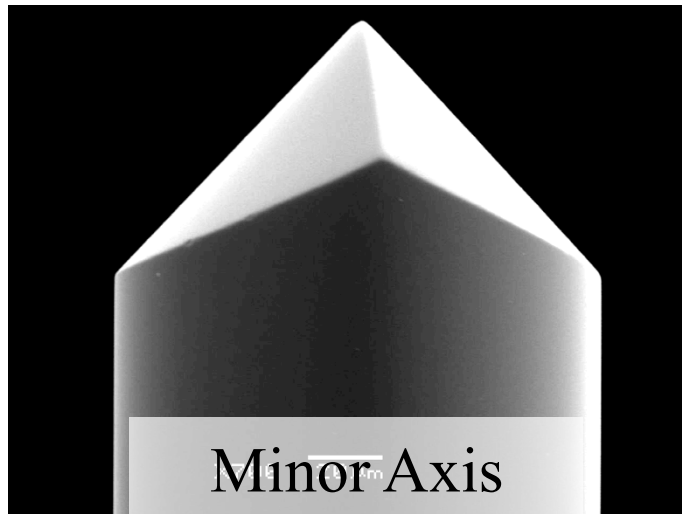
After slight fusion polish



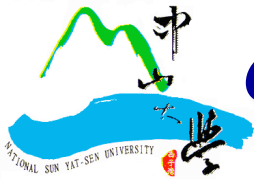
Endface



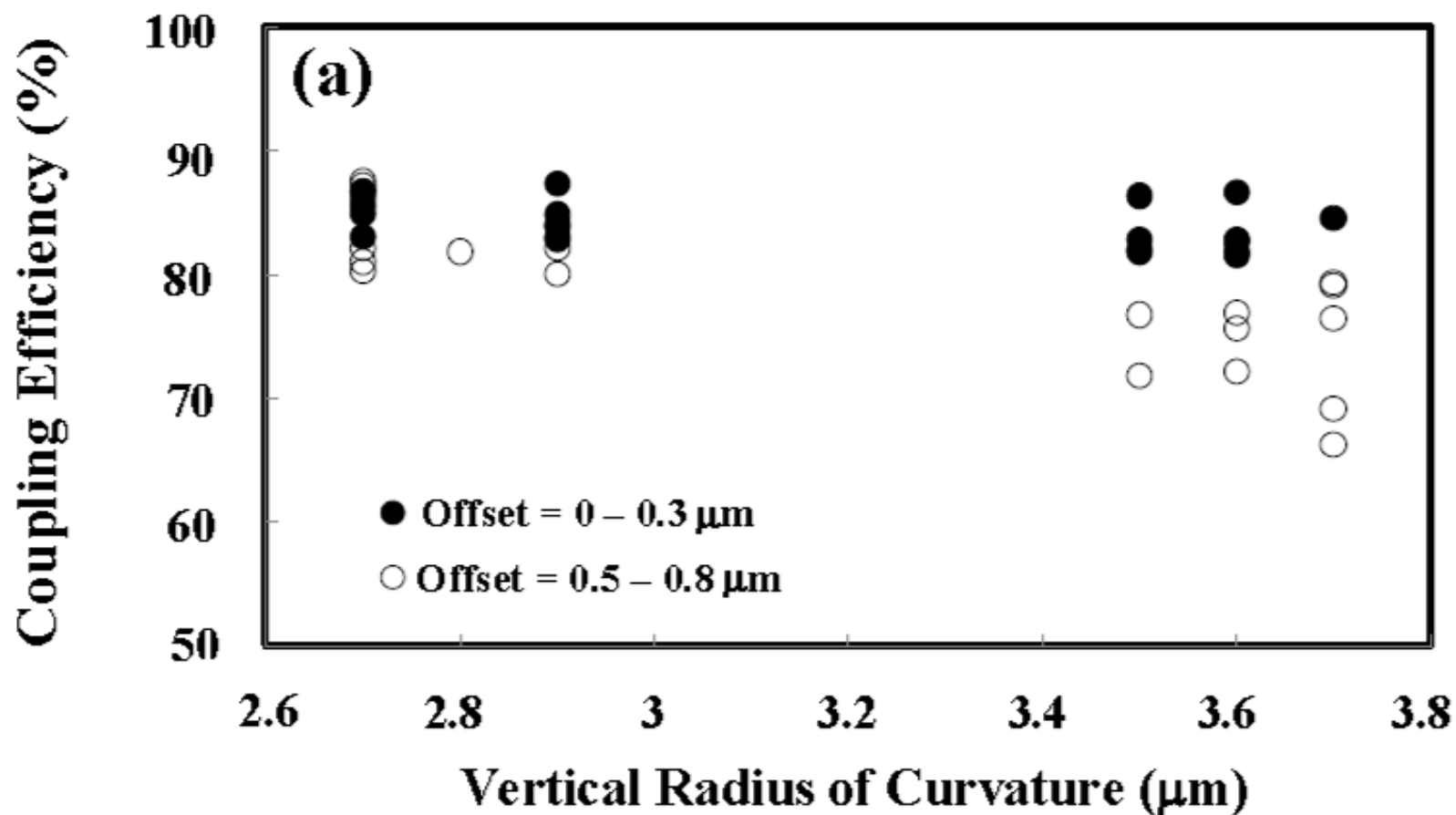
SEM of Microlens (DVCM)

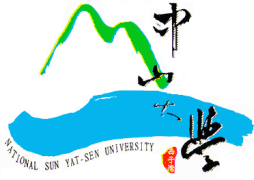


US patent : Double-Variable-Curvature Fiber Microlens
(Submitted, July 2011)

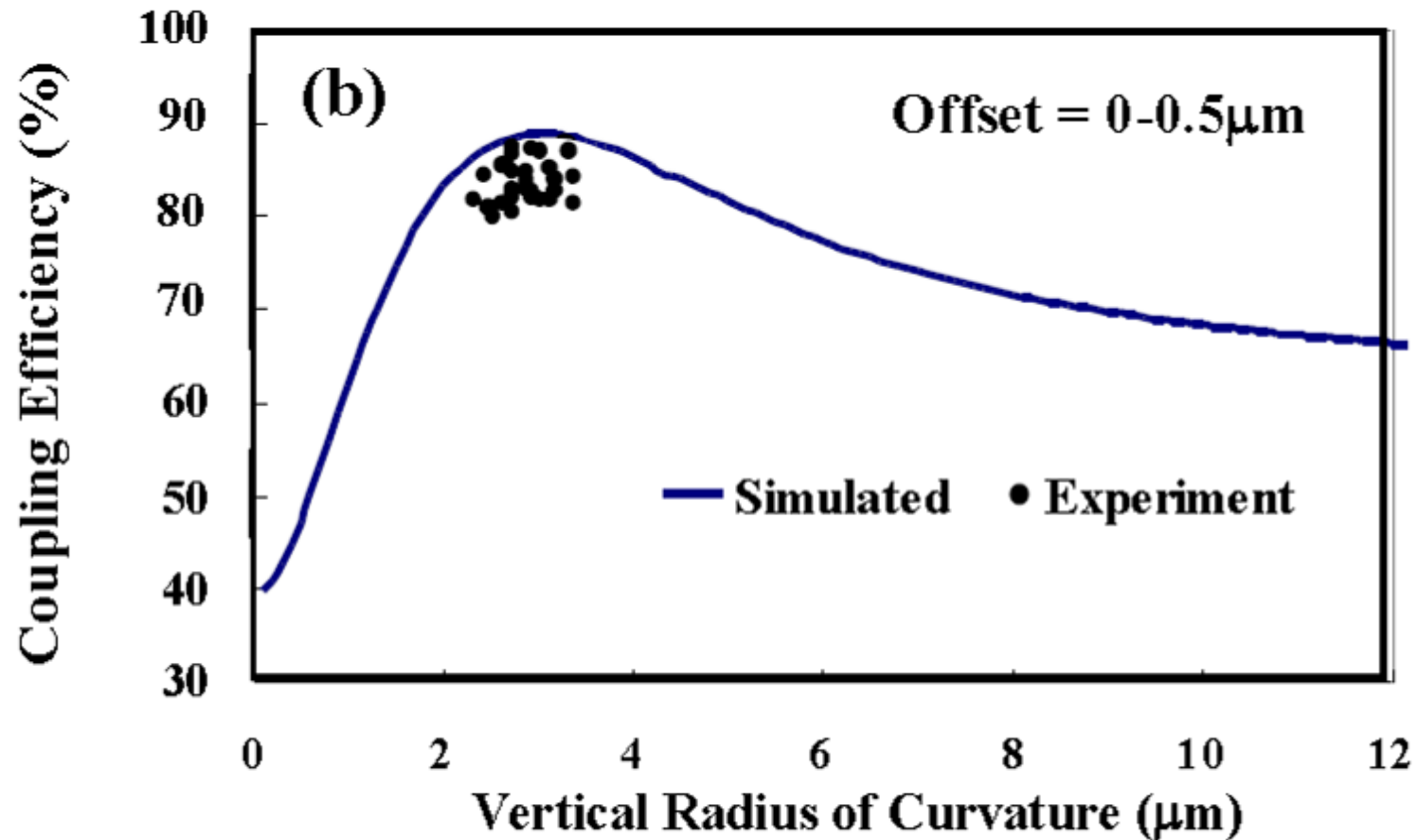


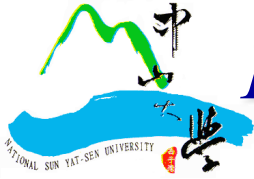
Coupling efficiency as a function of vertical radius of curvature for different offsets of DVCM



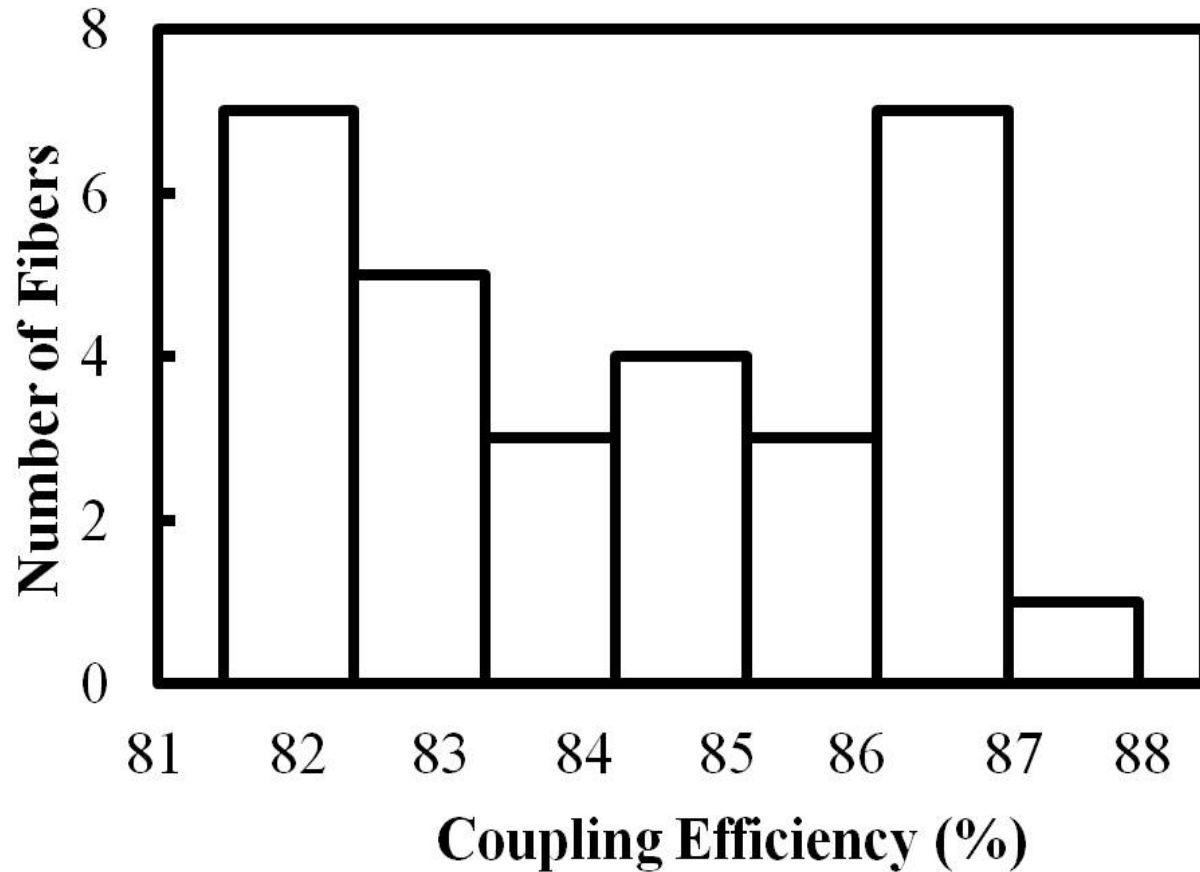


Coupling efficiency as a function of vertical radius of curvature for offset within 0.5 μm of DVCM

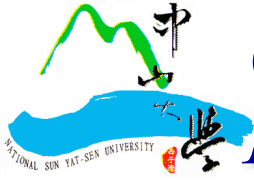




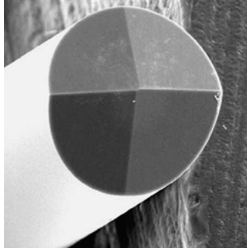
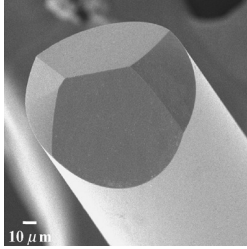
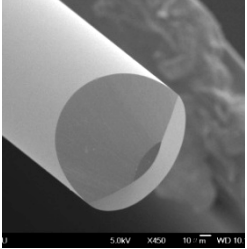
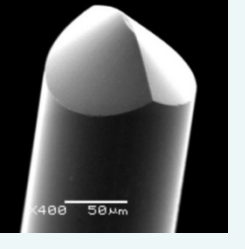
Histogram of measured coupling efficiencies between 980-nm laser diode and DVCM

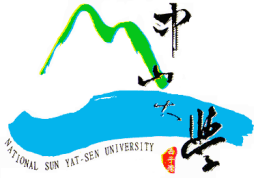


Average coupling efficiency = 84.5%



Comparison Structures of Asymmetric Fiber Endface (QPSFE, CWSFE, AESFE, DVCFE)

	QPSFE	CWSFE	AESFE	DVCFE
Shape				
Grinding step	4	3	1	1
Range/average offset (μm)	2.3/1.5	1.2/0.9	0.8/0.4	0.5/0.2
Max./Ave Coupling Efficiency	83%/	84%/	85%/71%	88%/84.5%
Advantage	High coupling efficiency.	High coupling efficiency.	High coupling efficiency, single-step grinding technique.	Higher yield and high coupling efficiency, single-step grinding technique.
Disadvantage	Low yield, multi-step grinding processes, fusing process.	Low yield, multi-step grinding processes, fusing process.	Low aspect ratio, requires fusing process.	



Outline

1. Motivation and Review

2. First Generation Microlens

One Mechanical Torque Control

3. Second Generation Microlens

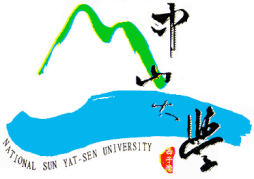
Two Electrical Torques Control

4. Third Generation Microlens

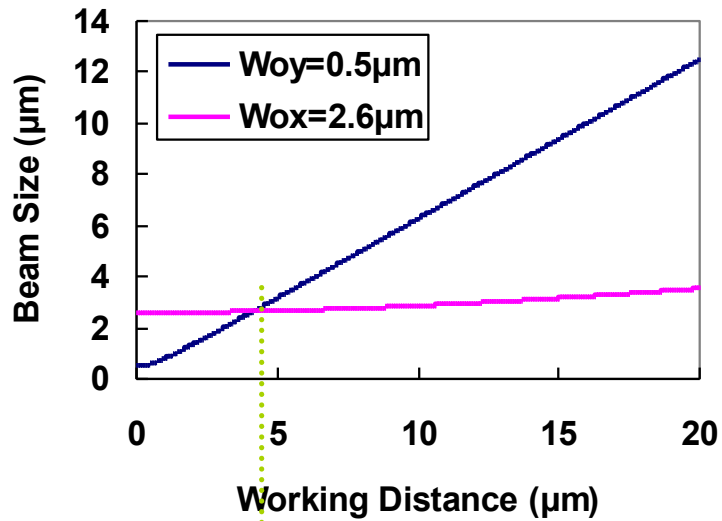
Three Electrical Torques Control


5. Near-Field Measurements

6. Conclusion

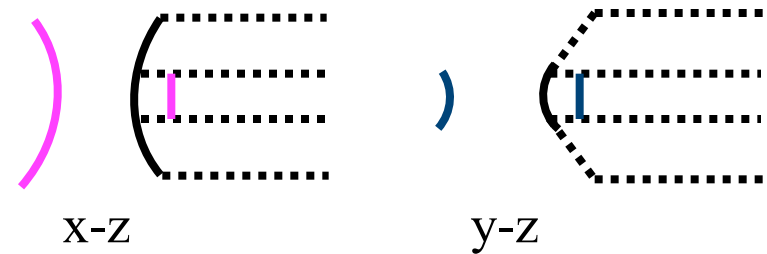
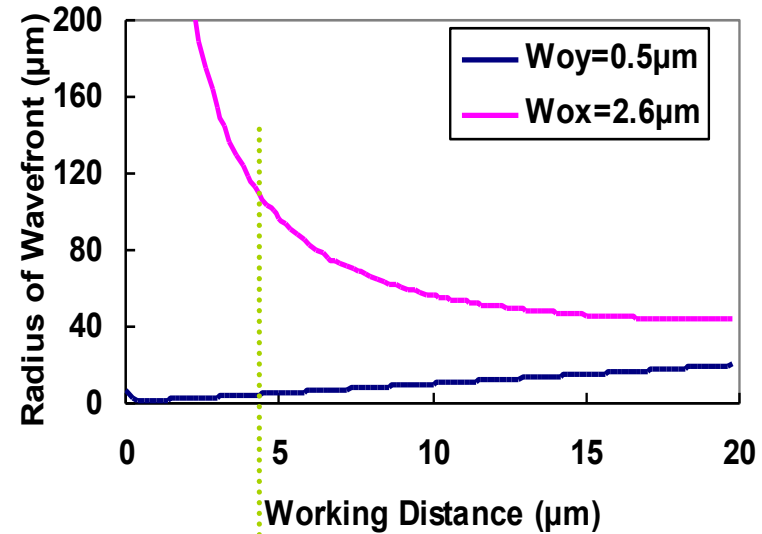


Mode Matching of Microlens Design

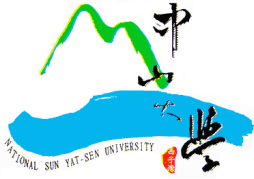



 $\omega_x(z) = \omega_y(z) \sim \omega_f$

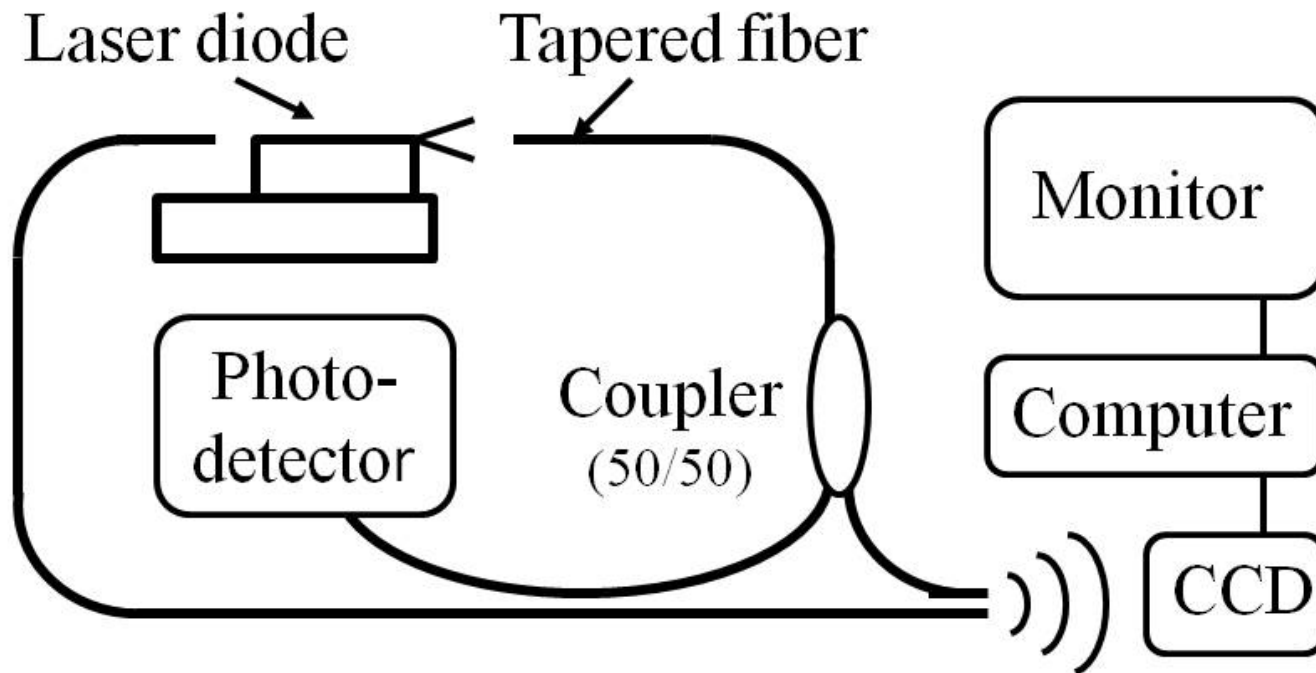
(a) Spot size matching



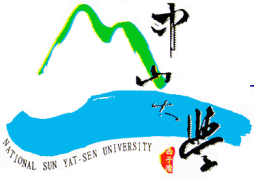
(b) Wavefront matching



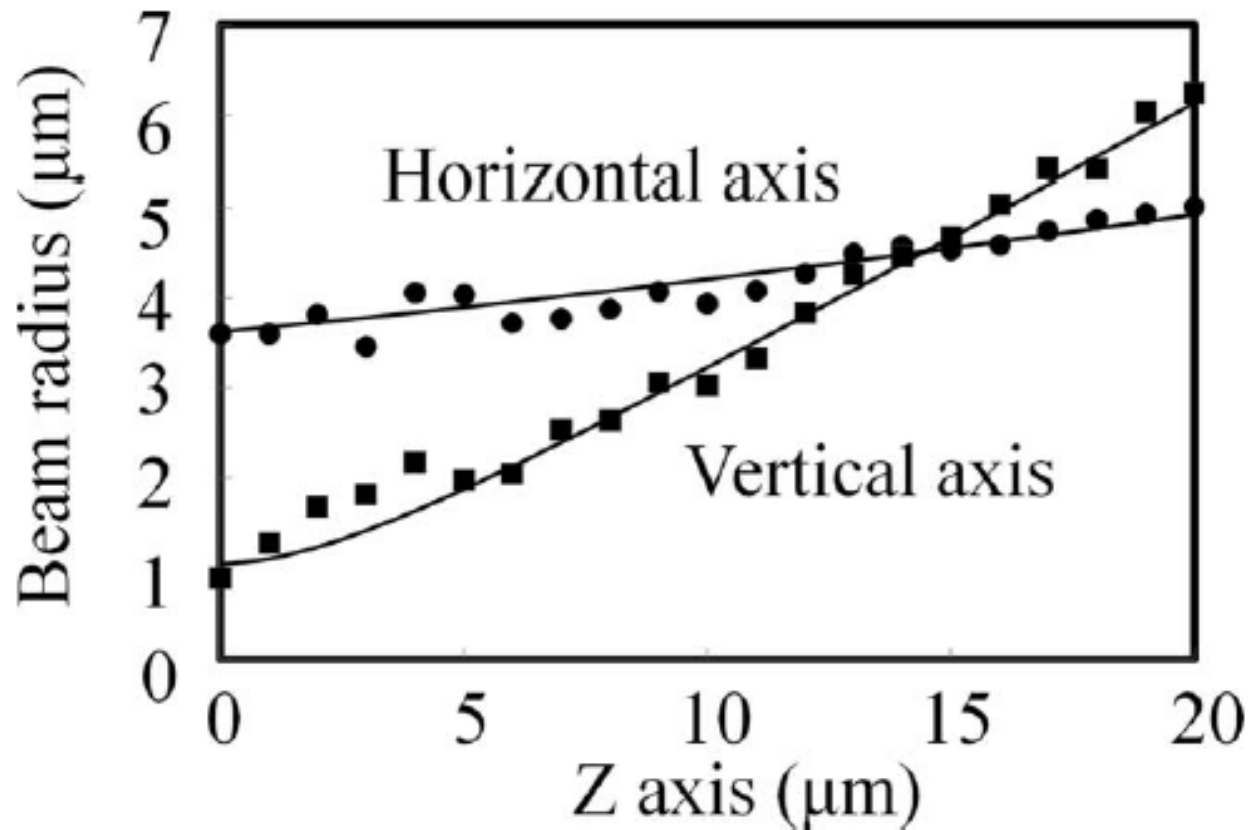
Near-Field Measurement of Laser Diode



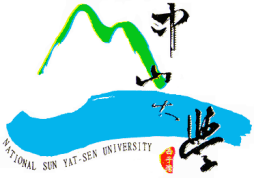
Y.K. Lu, P. Yeh, and **W.H. Cheng**, "Direct Near-Field Phase Measurement of Laser Diodes Employing Single-Mode Fiber Interferometer," *Opt. Letts.* 35, 3643 (2010).



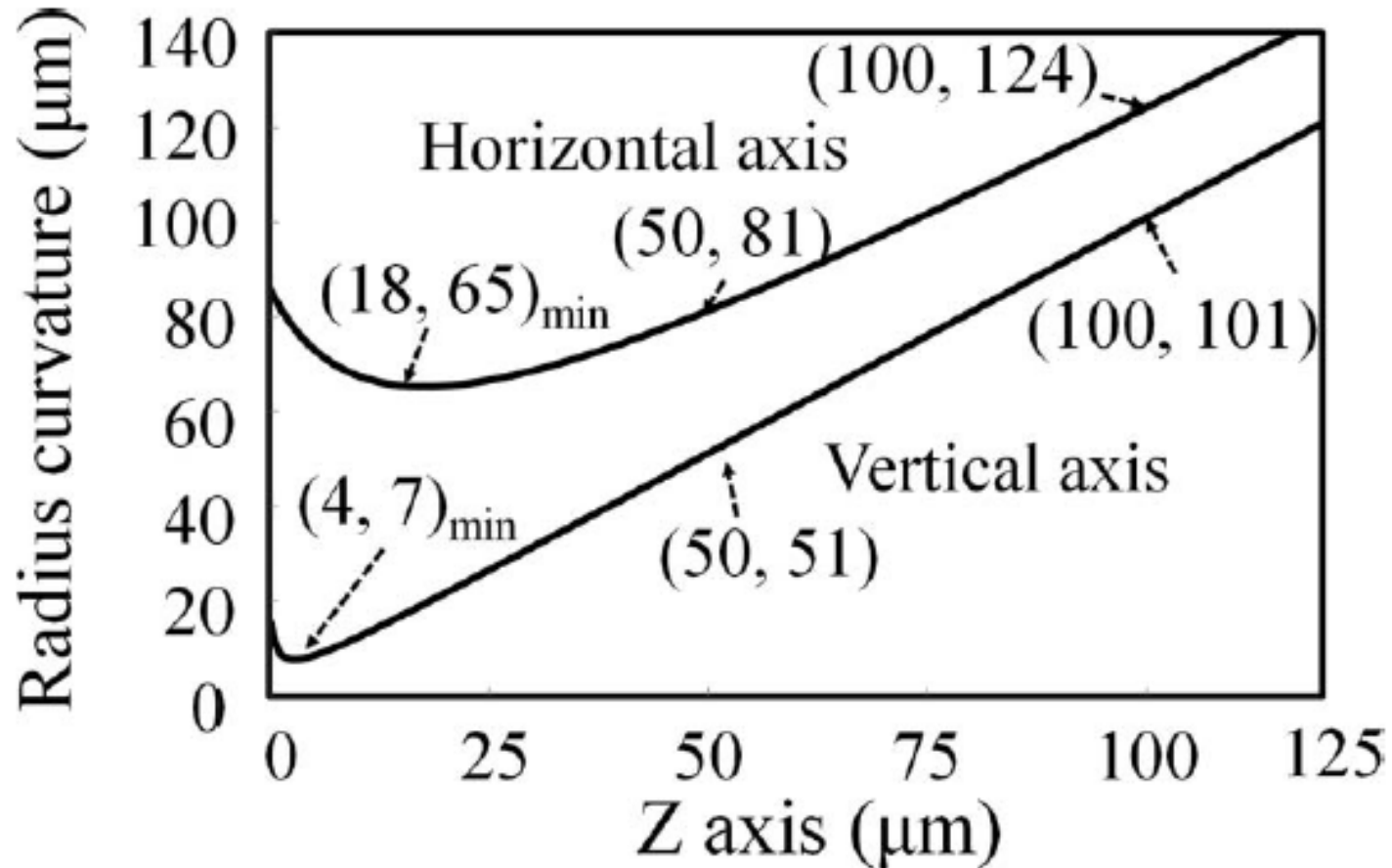
Beam Widths Obtained by Intensity Distribution and Gaussian Beam Fittings



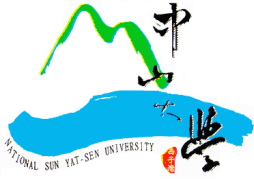
$z = 0 : R_x = 3.6 \mu\text{m}$ and $R_y = 0.9 \mu\text{m}$



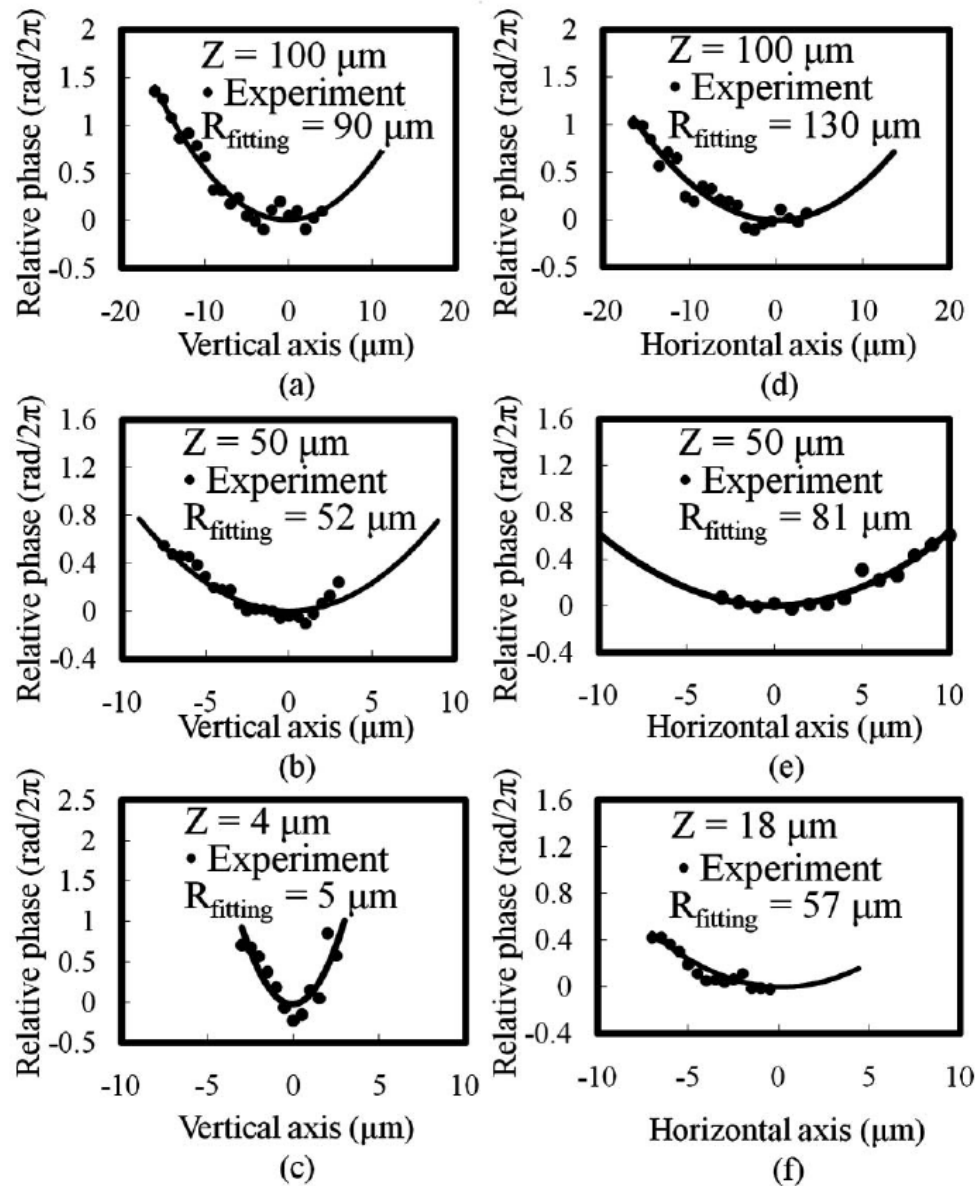
Radius Curvature of Wavefront



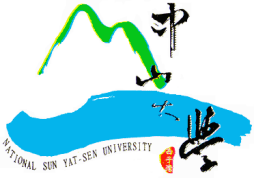
$$z = 0: R_x = 85.9 \mu\text{m} \text{ and } R_y = 15.7 \mu\text{m}$$



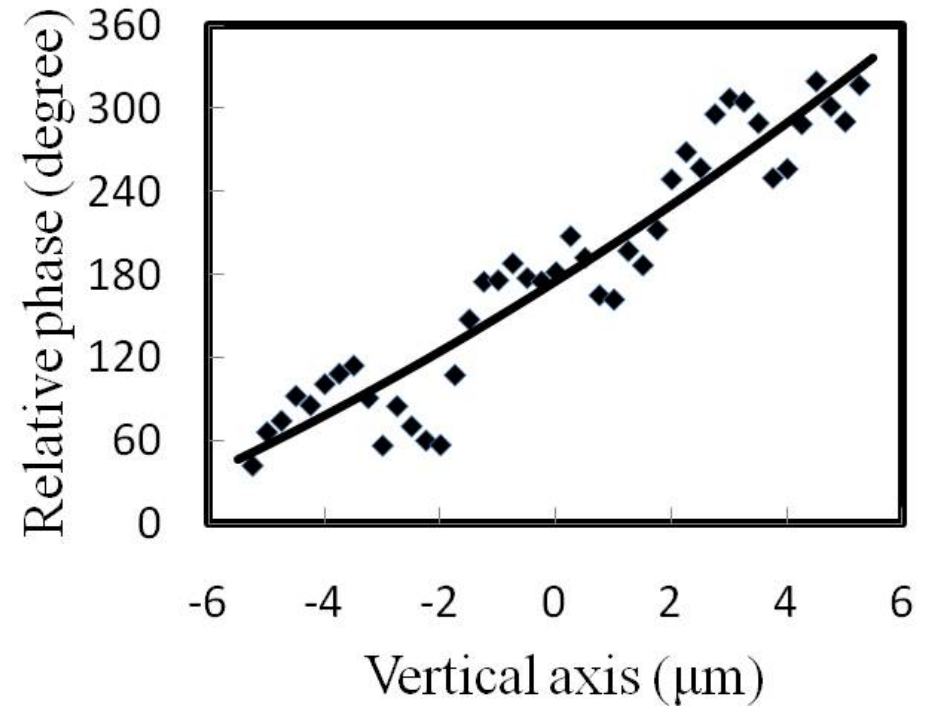
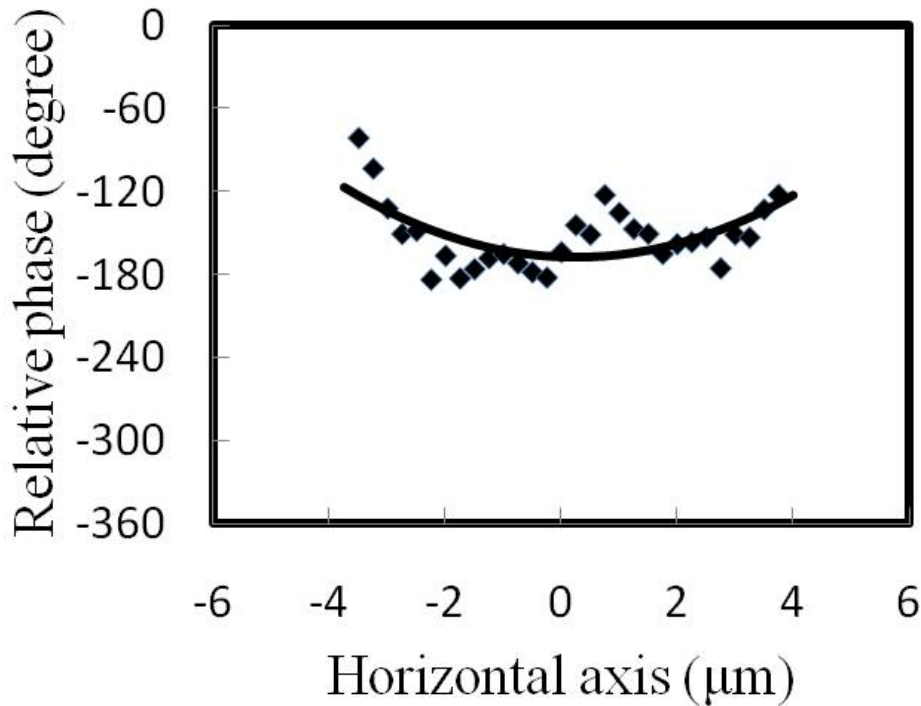
Relative phase distributions of laser along the vertical and horizontal axes



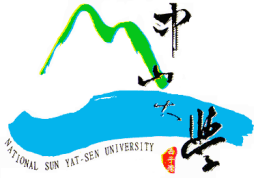
Curved
Wavefront



Phase distributions of fiber along the vertical and horizontal axes



$z = 0: R_x = 58 \mu\text{m}$ and $R_y = 338 \mu\text{m}$
Planar Wavefront



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One Mechanical Torque Control

3. Second Generation Microlens

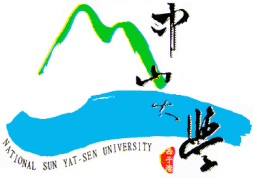
Two Electrical Torques Control

4. Third Generation Microlens

Three Electrical Torques Control

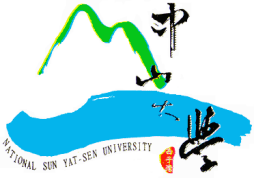
5. Near-Field Measurements

6. Conclusion



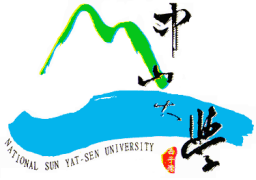
Conclusion

- We are able to fabricate any kinds of perfect microlenses employing a single-step grinding technique with fully automatic process, look like fabricate an **artwork**.
- The double-variable-curvature microlens (DVCM) was fabricated by precisely controlled both grinding offset and radius curvature leading to high-average and maximum coupling efficiency of 84.5% and 88%, respectively.
- High coupling photonics devices and modules require mode match (spot size and wavefront) between active and passive components. The measured radius curvature of wavefronts of laser diode and fiber employing near-field technique were in good agreement each other, the **science approach**.



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Thanks for your attention

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